

## Guiding and Manipulating Light at the Nanoscale



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NATO-ASI Summer school on  
Nanostructures for Optics and Photonics  
Centro Ettore Majorana  
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## Outline

- propagation of pulses
- nonlinear optics
- nanoscale optics
- nonlinear optics at the nanoscale

## Propagation of EM wave through medium

Governed by wave equation

$$\nabla^2 \vec{E} - \frac{\mu\epsilon}{c^2} \frac{\partial^2 \vec{E}}{\partial t^2} = 0$$

Solution:

$$\frac{\omega}{k} = \frac{1}{\sqrt{\epsilon\mu}} c = \frac{1}{n} c$$

where

$$\vec{E} = \vec{E}_o e^{i(kx - \omega t)}$$

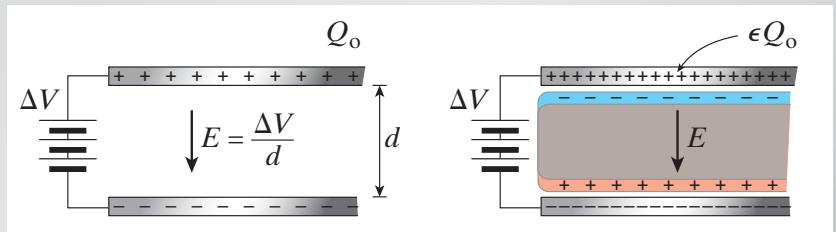
In nonferromagnetic media  $\mu \approx 1$ , and so  $n \approx \sqrt{\epsilon}$ .

In dispersive media  $n = n(\omega)$ .

## Propagation of EM wave through medium

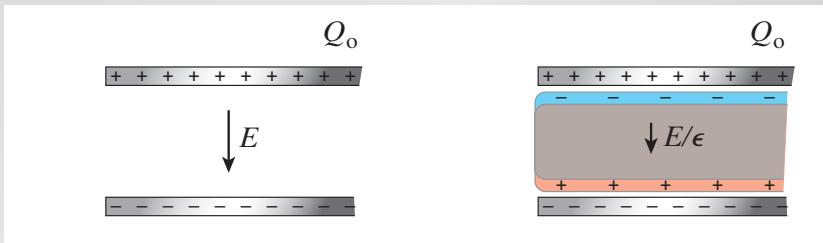
Dielectric constant measures increase in capacitance

$$\epsilon = \frac{C_d}{C_0}$$



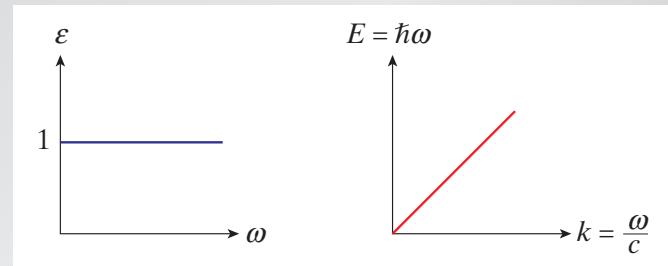
## Propagation of EM wave through medium

Alternatively  $\epsilon$  is measure of attenuation of electric field



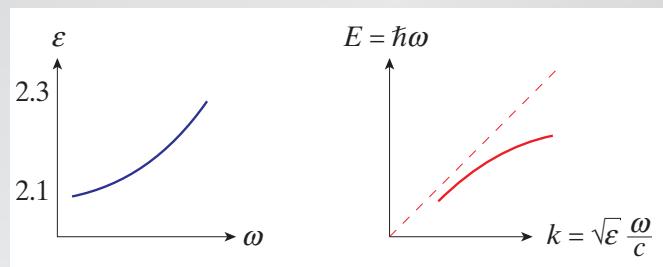
## Propagation of EM wave through medium

$$\text{In vacuum: } f\lambda = \frac{\omega}{k} = c \quad \Rightarrow \quad \omega = c k$$

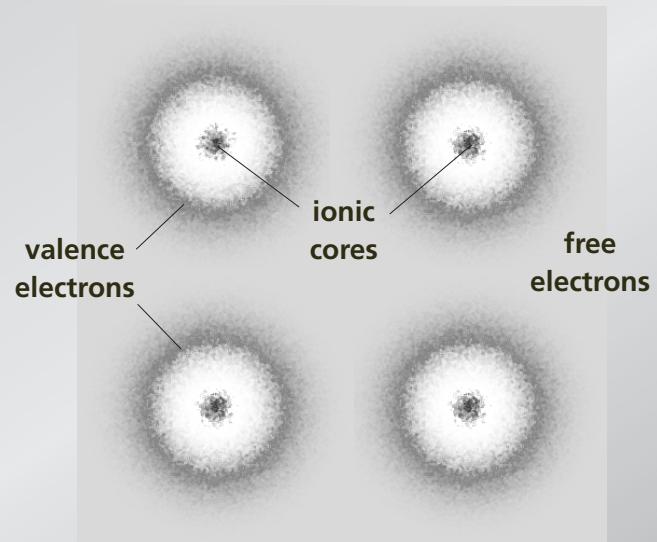


## Propagation of EM wave through medium

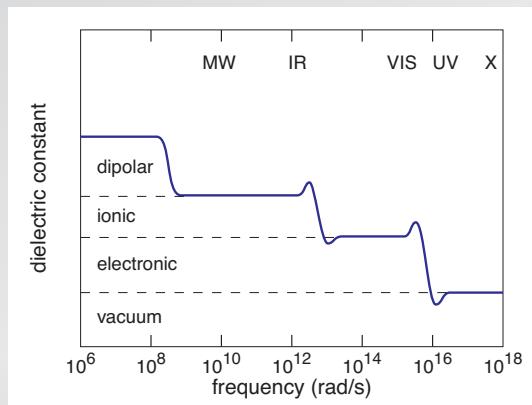
$$\text{In medium: } v = \frac{c}{\sqrt{\epsilon(\omega)}} = \frac{c}{n} \quad \Rightarrow \quad \omega = \frac{c}{\sqrt{\epsilon}} k$$



## Which charges participate?



## Dielectric function



## Bound electrons

**Electron on a string:**  $F_{binding} = -m_e \omega_o^2 x$

$$F_{damping} = -m_e \gamma \frac{dx}{dt}$$

$$F_{driving} = -eE = -eE_o e^{-i\omega t}$$

**Equation of motion:**  $m \frac{d^2x}{dt^2} = \sum F$

$$m \frac{d^2x}{dt^2} + m\gamma \frac{dx}{dt} + m\omega_o^2 x = -eE$$

## Bound electrons

**Steady state:** electron oscillates at driving frequency

$$x(t) = x_o e^{-i\omega t} \quad x_o = -\frac{e}{m} \frac{1}{(\omega_o^2 - \omega^2) - i\gamma\omega} E_o$$

**Oscillating dipole**

$$p(t) = -ex(t) = \frac{e^2}{m} \frac{1}{(\omega_o^2 - \omega^2) - i\gamma\omega} E_o e^{-i\omega t}$$

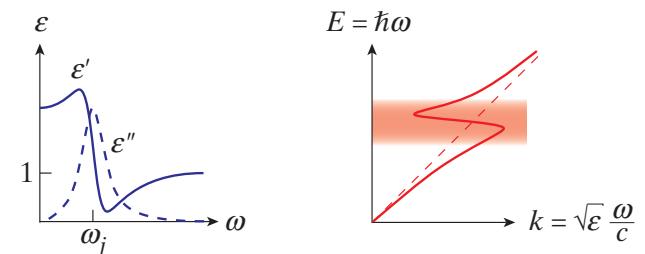
**Polarization**

$$P(t) = \left( \frac{Ne^2}{m} \right) \sum_j \frac{f_j}{(\omega_j^2 - \omega^2) - i\gamma_j\omega} E(t) \equiv \epsilon_o \chi_e E(t)$$

## Bound electrons

**Dielectric function**

$$\epsilon(\omega) \equiv 1 + \chi_e = 1 + \frac{Ne^2}{\epsilon_o m} \sum_j \frac{f_j}{(\omega_j^2 - \omega^2) - i\gamma_j\omega}$$



## Free electrons

No binding:

$$F_{binding} \approx 0$$

**Equation of motion:**  $m \frac{d^2x}{dt^2} + m\gamma \frac{dx}{dt} = -eE$

**Solution:**  $x(t) = \frac{e}{m} \frac{1}{\omega^2 + i\gamma\omega} E(t)$  **(no resonance)**

Low frequency ( $\omega \ll \gamma$ )  $\Rightarrow$  current generated

$$J = -Ne \frac{dx}{dt} = \frac{Ne^2}{m} \frac{1}{\gamma - i\omega} E \approx \frac{Ne^2}{m\gamma} E \equiv \sigma E$$

## Free electrons

$\omega \gg \gamma$ :  $\sigma$  complex  $\Rightarrow J$  out of phase with  $E$

**Dipole:**

$$p(t) = -ex(t) = -\frac{e^2}{m} \frac{1}{\omega^2 + i\gamma\omega} E(t)$$

**Polarization:**

$$P(t) = -\frac{Ne^2}{m} \frac{1}{\omega^2 + i\gamma\omega} E(t) \equiv \epsilon_o \chi_e E(t)$$

**Dielectric function:**

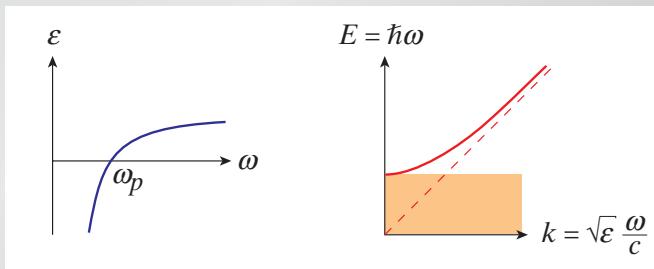
$$\epsilon(\omega) \equiv 1 + \chi_e = 1 - \frac{Ne^2}{m\epsilon_o} \frac{1}{\omega^2 + i\gamma\omega} = \epsilon'(\omega) + i\epsilon''(\omega)$$

## Free electrons

$$\epsilon(\omega) \equiv 1 + \chi_e = 1 - \frac{Ne^2}{m\epsilon_o} \frac{1}{\omega^2 + i\gamma\omega} = \epsilon'(\omega) + i\epsilon''(\omega)$$

Little damping:  $\gamma \approx 0 \Rightarrow \epsilon'' = 0$

$$\epsilon'(\omega) = 1 - \frac{Ne^2}{m\epsilon_o} \frac{1}{\omega^2} \equiv 1 - \frac{\omega_p^2}{\omega^2}$$

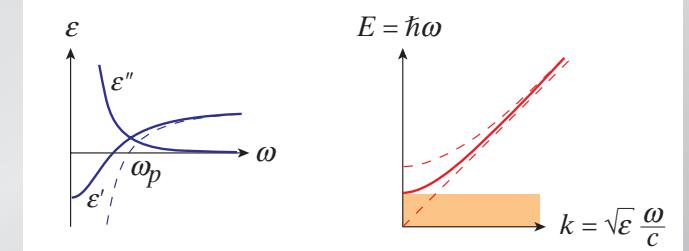


## Free electrons

$$\epsilon(\omega) \equiv 1 + \chi_e = 1 - \frac{Ne^2}{m\epsilon_o} \frac{1}{\omega^2 + i\gamma\omega} = \epsilon'(\omega) + i\epsilon''(\omega)$$

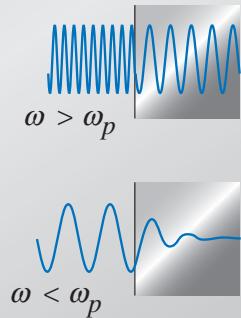
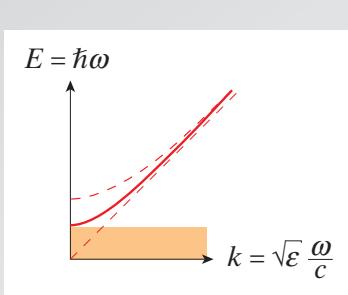
Add damping:

$$\gamma \leq \omega_p$$



## Free electrons

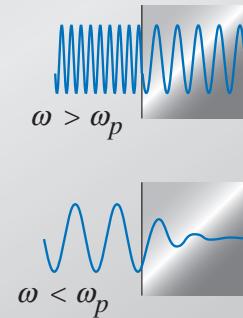
Plasma acts like a high-pass filter



## Free electrons

Plasma acts like a high-pass filter

$\log N$ (cm <sup>-3</sup> )	$\omega_p$ (rad s <sup>-1</sup> )	$\lambda_p$
22	$6 \times 10^{15}$	330 nm
18	$6 \times 10^{13}$	33 μm
14	$6 \times 10^{11}$	3.3 mm
10	$6 \times 10^9$	0.33 m



## Pulse dispersion

Consider two propagating waves:

$$y_1 = A \sin(k_1 x - \omega_1 t) \quad \text{and} \quad y_2 = A \sin(k_2 x - \omega_2 t)$$

propagating at speeds

$$v_1 = \frac{\omega_1}{k_1} = f_1 \lambda_1 \quad \text{and} \quad v_2 = \frac{\omega_2}{k_2} = f_2 \lambda_2.$$

Superposition:

$$y = A [\sin(k_1 x - \omega_1 t) + \sin(k_2 x - \omega_2 t)]$$

$$\sin \alpha + \sin \beta = 2 \cos\left(\frac{\alpha - \beta}{2}\right) \sin\left(\frac{\alpha + \beta}{2}\right)$$

## Pulse dispersion

$$y = 2A \cos\left[\frac{1}{2}[(k_1 - k_2)x - (\omega_1 - \omega_2)t]\right] \sin\left[\frac{k_1 + k_2}{2}x - \frac{\omega_1 + \omega_2}{2}t\right]$$

Let:  $k_1 - k_2 \equiv \Delta k$  and  $\omega_1 - \omega_2 \equiv \Delta \omega$

$$\frac{k_1 + k_2}{2} \equiv k \quad \text{and} \quad \frac{\omega_1 + \omega_2}{2} \equiv \omega$$

and so:

$$y = 2A \cos\left(\frac{1}{2}(x\Delta k - t\Delta \omega)\right) \sin(kx - \omega t)$$

traveling sine wave, with amplitude modulation.

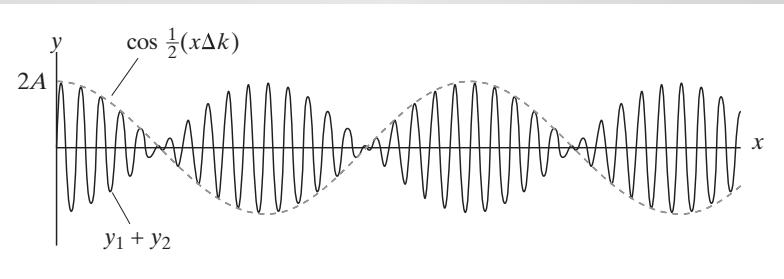
## Pulse dispersion

$$y = 2A \cos \frac{1}{2}(x\Delta k - t\Delta\omega) \sin(kx - \omega t)$$

At  $t = 0$ :

$$y = 2A \cos \frac{1}{2}(x\Delta k) \sin(kx)$$

envelope   carrier



## Pulse dispersion

$$y = 2A \cos \frac{1}{2}(x\Delta k - t\Delta\omega) \sin(kx - \omega t)$$

If no dispersion

$$v_p = \frac{\omega_1}{k_1} = \frac{\omega_2}{k_2}$$

group velocity:

$$v_g = \frac{\Delta\omega}{\Delta k} = \frac{\omega_1 - \omega_2}{k_1 - k_2} = \frac{\omega_1/k_1 - \omega_2/k_1}{1 - k_2/k_1} = \frac{v_p - \omega_2/k_1}{1 - k_2/k_1}$$

$$v_g = \frac{v_p - \omega_2/k_2(k_2/k_1)}{1 - k_2/k_1} = v_p \frac{1 - k_2/k_1}{1 - k_2/k_1} = v_p$$

## Pulse dispersion

$$y = 2A \cos \frac{1}{2}(x\Delta k - t\Delta\omega) \sin(kx - \omega t)$$

speed of carrier ('phase velocity'):

$$v_p = \frac{\omega}{k} = f\lambda$$

speed of envelope ('group velocity'):

$$v_g = \frac{\Delta\omega}{\Delta k} = \frac{d\omega}{dk}$$

## Pulse dispersion

$$y = 2A \cos \frac{1}{2}(x\Delta k - t\Delta\omega) \sin(kx - \omega t)$$

If no dispersion

$$v_p = \frac{\omega_1}{k_1} = \frac{\omega_2}{k_2}$$

group and phase velocities are the same:

$$v_g = v_p$$

and so the envelope and carrier travel together

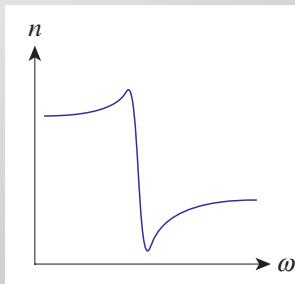
## Pulse dispersion

$$y = 2A \cos \frac{1}{2}(x\Delta k - t\Delta\omega) \sin(kx - \omega t)$$

Types of dispersion:

$$\frac{dn}{d\omega} > 0 \quad \text{normal dispersion}$$

$$v_g < v_p$$



$$\frac{dn}{d\omega} = 0 \quad \text{no dispersion}$$

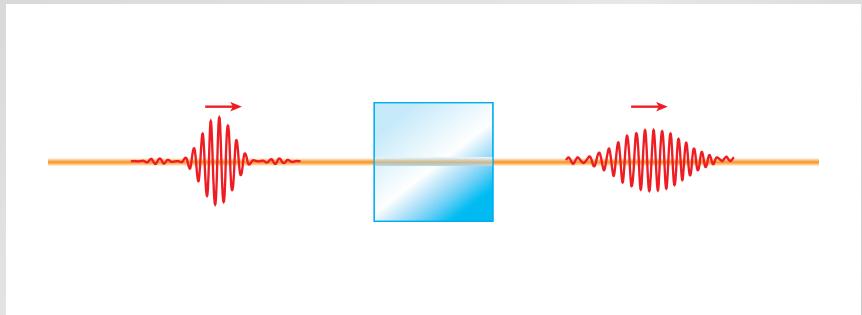
$$v_g = v_p$$

$$\frac{dn}{d\omega} < 0 \quad \text{anomalous dispersion}$$

$$v_g > v_p$$

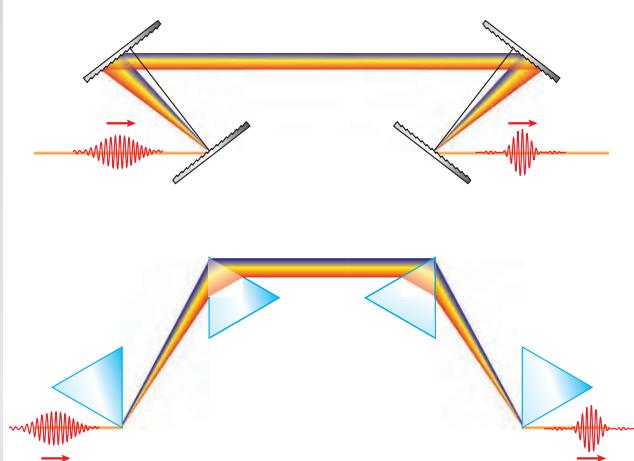
## Pulse dispersion

medium causes pulse to stretch



compensate by rearranging spectral components!

## Pulse dispersion compensation



## Pulse dispersion

Write dispersion as Taylor series:

$$\omega(k) = \omega_o + \left( \frac{d\omega}{dk} \right)_{k=k_o} (k - k_o) + \frac{1}{2} \left( \frac{d^2\omega}{dk^2} \right)_{k=k_o} (k - k_o)^2$$

let

$$u \equiv \left( \frac{d\omega}{dk} \right)_{k=k_o} \quad \text{and} \quad w \equiv \left( \frac{d^2\omega}{dk^2} \right)_{k=k_o}.$$

group velocity:  $v_g = \frac{d\omega}{dk} = u + wk$

if  $w = 0$ , then group velocity and pulse shape constant!

## Pulse dispersion compensation

So not path length but  $\frac{d^2\phi}{d\omega^2}$  matters!

	$\frac{dl_{eff}}{d\omega}$	$\frac{d^2\phi}{d\omega^2}$
dispersion	+	+
gratings	-	-
prisms	+	-

## Outline

- propagation of pulses
- nonlinear optics
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- nonlinear optics at the nanoscale

## Nonlinear optics

Linear optics:

$$\vec{P} = \chi \vec{E}$$

Nonlinear polarization:

$$P = \chi^{(1)}E + \chi^{(2)}E^2 + \chi^{(3)}E^3 + \dots$$

and so:

$$P = P^{(1)} + P^{(2)} + P^{(3)} + \dots$$

$$P^{(2)} \approx P^{(1)} \text{ when } E = E_{at} \approx \frac{e}{a}, \text{ and so } \chi^{(n)} \approx \frac{\chi^{(1)}}{E_{at}^{n-1}}.$$

Nonlinear polarization can drive new field:

$$\nabla^2 \vec{E} + \frac{n^2}{c^2} \frac{\partial^2 \vec{E}}{\partial t^2} = \frac{4\pi}{c^2} \frac{\partial^2 \vec{P}}{\partial t^2}$$

But even terms disappear in media with inversion symmetry!

$$\vec{P}^{(2)} = \chi^{(2)} \cdot \vec{E} \vec{E}$$

Invert all vectors:

$$-\vec{P}^{(2)} = \chi^{(2)} \cdot (-\vec{E})(-\vec{E})$$

and so  $\chi^{(2)} = -\chi^{(2)} = 0$ .

## Nonlinear optics

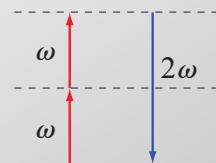
Consider oscillating electric field:

$$E(t) = E e^{i\omega t} + \text{c.c.}$$

Second-order polarization:

$$P^{(2)}(t) = \chi^{(2)} E^2(t) = \frac{1}{2} \chi^{(2)} E E^* + \frac{1}{4} [\chi^{(2)} E^2 e^{-2\omega t} + \text{c.c.}]$$

Physical interpretation:



## Nonlinear optics

Can also cause frequency mixing! Let

$$E(t) = E_1 e^{-i\omega_1 t} + E_2 e^{-i\omega_2 t}$$

Second-order polarization will contain terms with

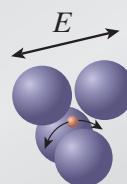
$$2\omega_1 \text{ (SHG)}, 2\omega_2 \text{ (SHG)}, \omega_1 + \omega_2 \text{ (SFG)}, \omega_1 - \omega_2 \text{ (DFG)}$$

Physical interpretation:



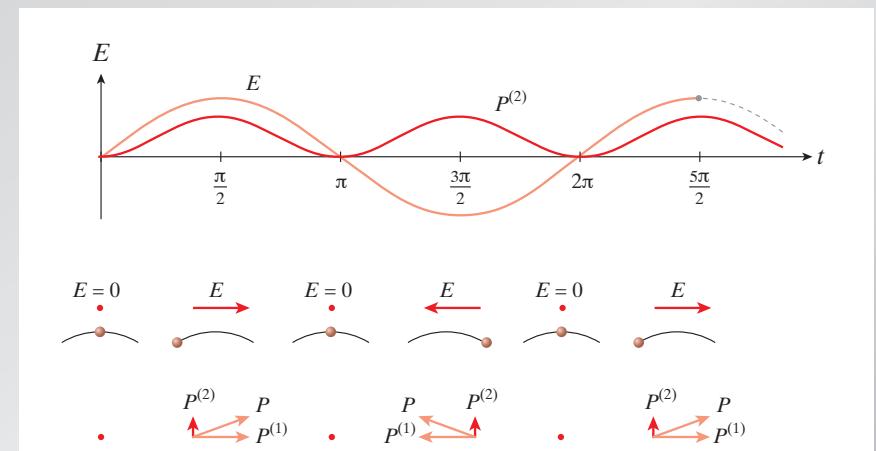
## Nonlinear optics

Nonlinear response:  $P^{(2)} = \chi^{(2)} E^2$



## Nonlinear optics

Nonlinear response:  $P^{(2)} = \chi^{(2)} E^2$



## Nonlinear optics

Third-order polarization:  $P^{(3)}(t) = \chi^{(3)}E^3(t)$

3 frequencies, 3 terms + c.c.: complicated! In general

$$\cos^3 \omega t = \frac{1}{4} \cos 3\omega t + \frac{3}{4} \cos \omega t$$

Intensity dependent term at fundamental frequency:

$$P^{(3)}(t) = \chi^{(3)}E(t)E^*(t)E(t) = \chi^{(3)}I(t)E(t)$$

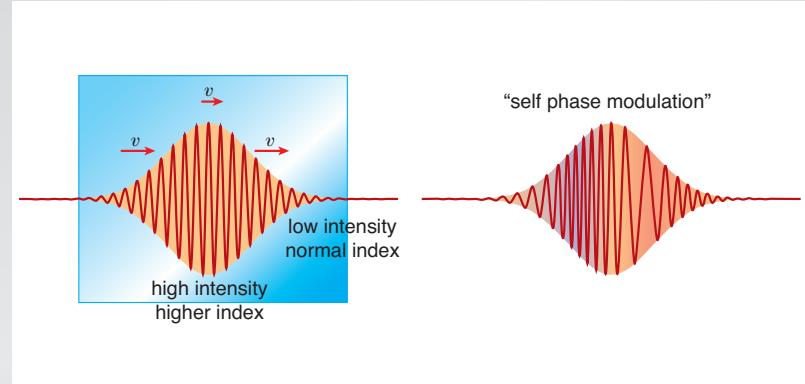
and so  $P = P^{(1)} + P^{(3)} = (\chi^{(1)} + \chi^{(3)}I)E \equiv \chi_{eff}E$

$$n = \sqrt{\epsilon} = \sqrt{1 + \chi_{eff}} \approx \sqrt{1 + \chi^{(1)}} + \frac{1}{2} \frac{\chi^{(3)}I}{\sqrt{1 + \chi^{(1)}}} = n_o + n_2I$$

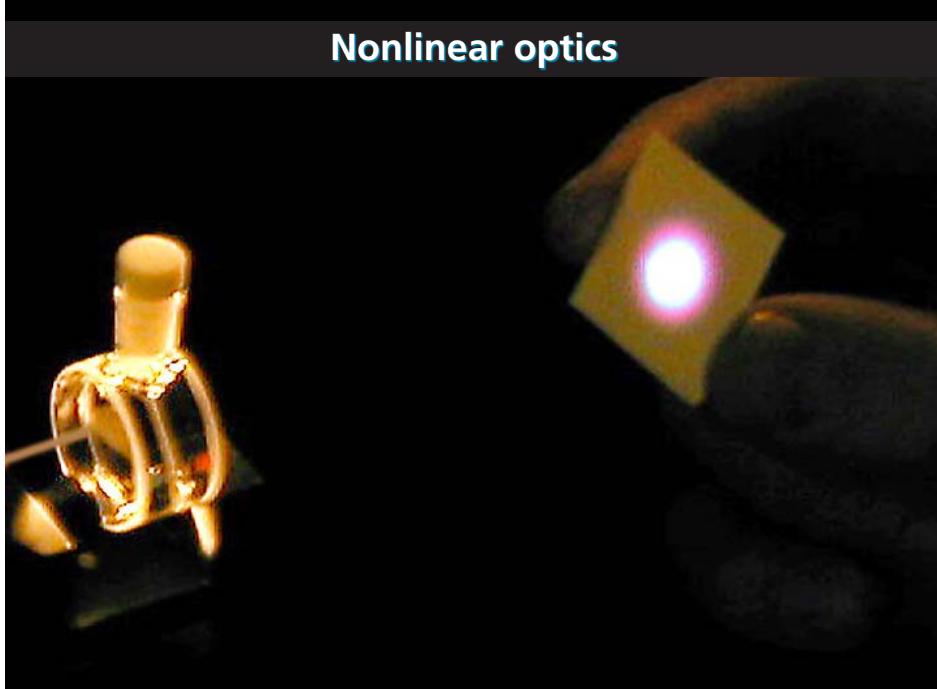
## Nonlinear optics

Intensity-dependent index of refraction:

$$n = n_o + n_2I$$



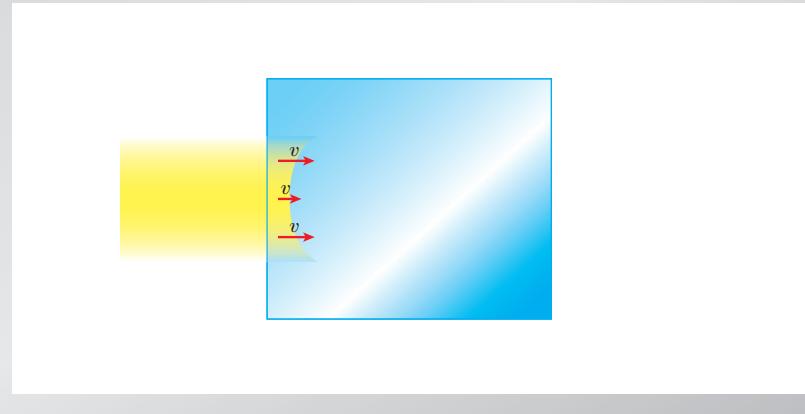
## Nonlinear optics



## Nonlinear optics

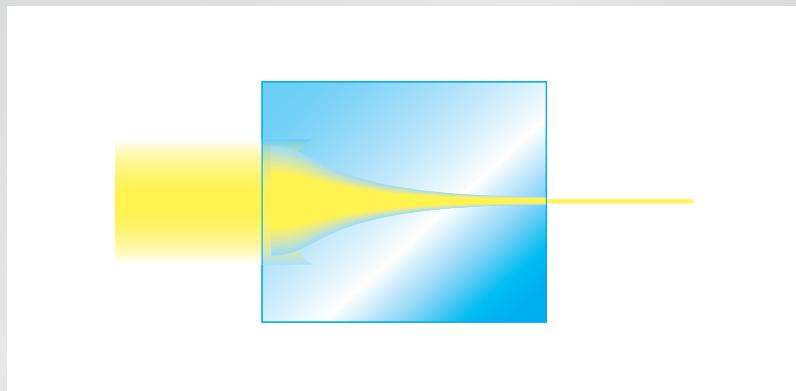
Intensity-dependent index of refraction:

$$n = n_o + n_2I$$



## Nonlinear optics

self-focusing



## Nonlinear optics

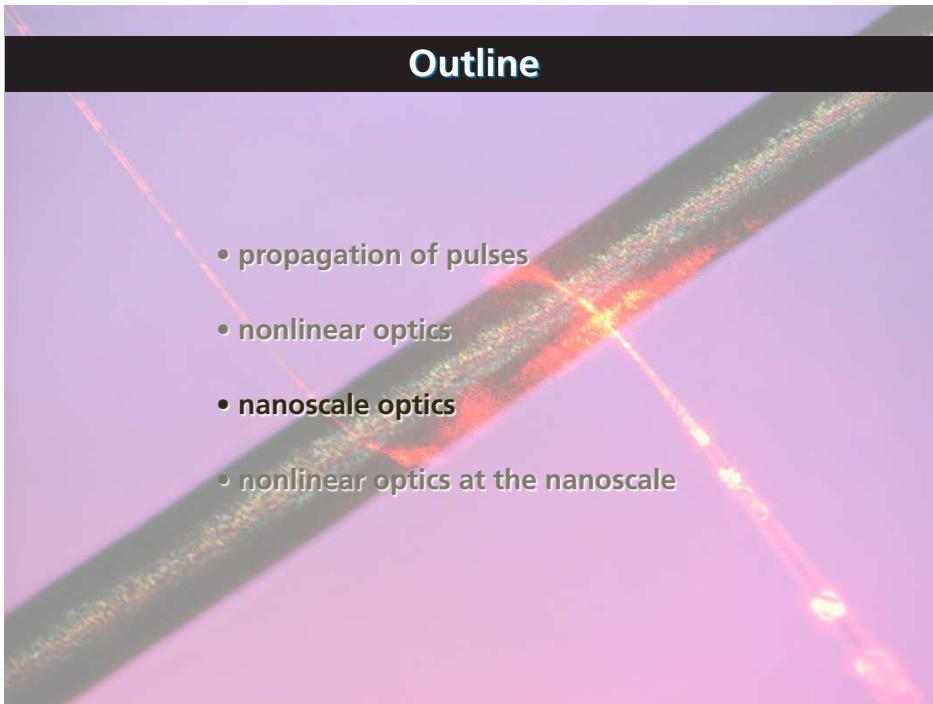
but susceptibility is complex!

susceptibility	real part	imaginary part
linear	refraction	absorption
nonlinear	SHG, SFG, DFG, THG,...	multiphoton absorption

$$\alpha = \alpha_o + \beta I + \gamma I^2 + \dots$$

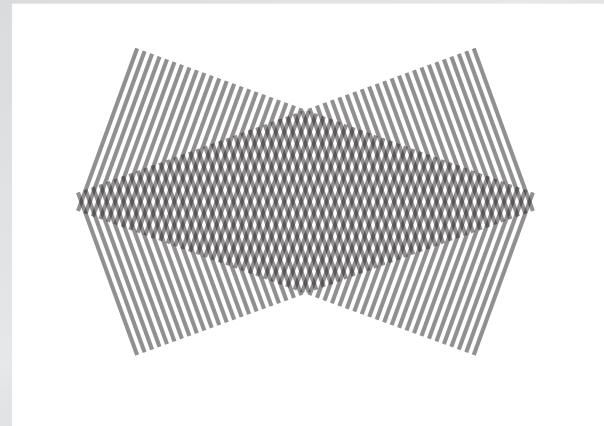
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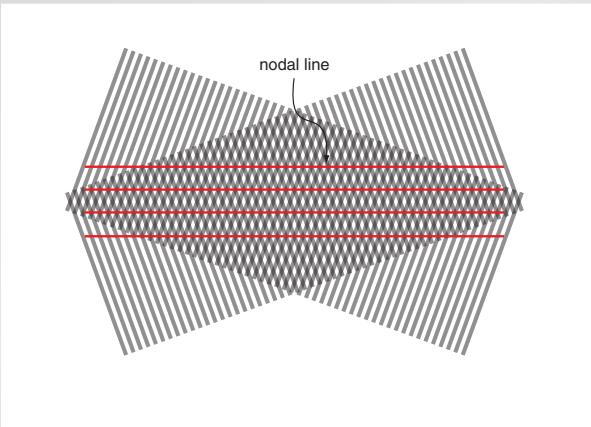
## Waveguiding

two crossed planar waves...



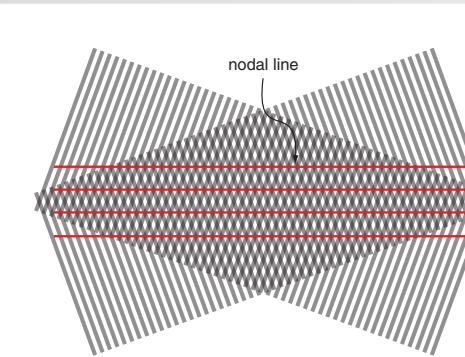
## Waveguiding

...cause an interference pattern



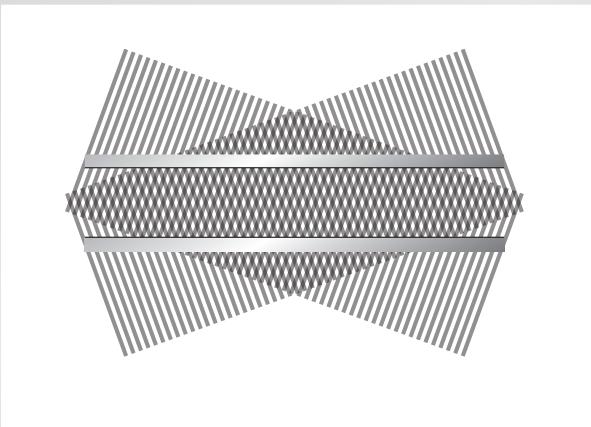
## Waveguiding

$E = 0$  on the nodal lines



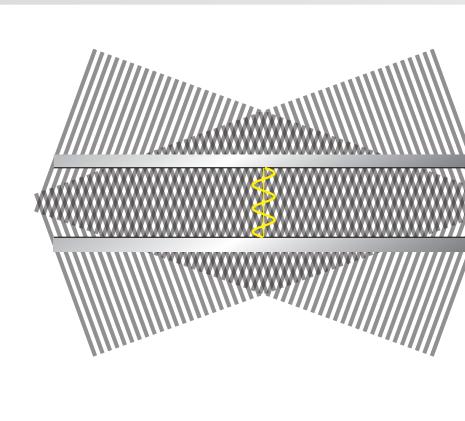
## Waveguiding

...satisfying boundary conditions for planar-mirror waveguide



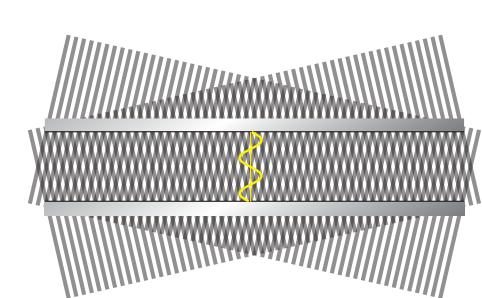
## Waveguiding

transverse standing wave, traveling along axis



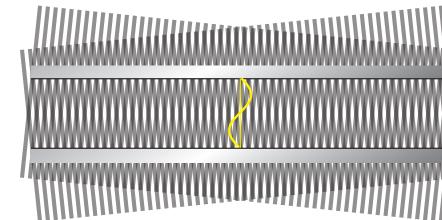
## Waveguiding

change angle of incident waves...



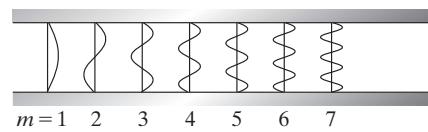
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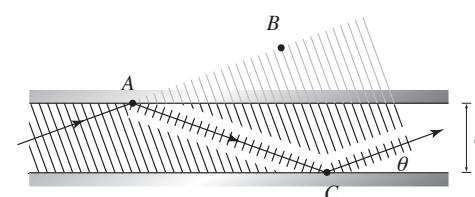


## Waveguiding

boundary conditions only satisfied for certain  $\theta$



standing wave in y-direction, traveling in z-direction



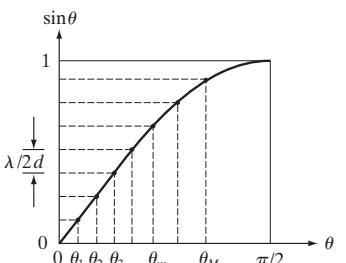
self consistency:

$$AC - AB = 2d \sin\theta = m\lambda \quad (m = 1, 2, \dots)$$

so:

$$\sin\theta_m = m \frac{\lambda}{2d}$$

## Waveguiding



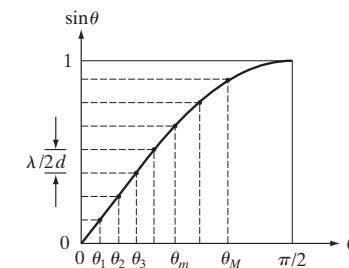
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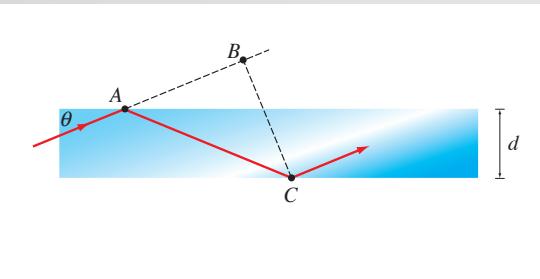
## Waveguiding



**number of modes:**

$$M = \frac{2d}{\lambda}$$

## Waveguiding



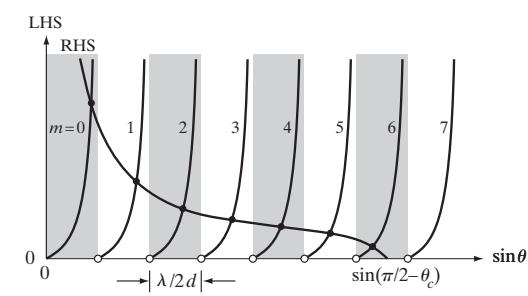
**self consistency:**

$$AC - AB = 2d \sin \theta - \frac{\varphi_r}{\pi} \lambda = m\lambda \quad (m = 0, 1, 2\dots)$$

**so:**

$$\tan \left( \frac{\pi d}{\lambda} \sin \theta - m \frac{\pi}{2} \right) = \left( \frac{\sin^2(\pi/2 - \theta_c)}{\sin^2 \theta} - 1 \right)^{1/2}$$

## Waveguiding



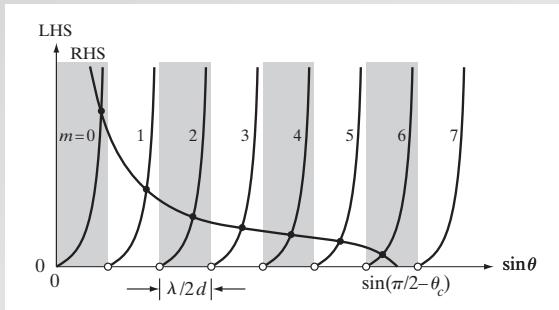
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$$\tan \left( \frac{\pi d}{\lambda} \sin \theta - m \frac{\pi}{2} \right) = \left( \frac{\sin^2(\pi/2 - \theta_c)}{\sin^2 \theta} - 1 \right)^{1/2}$$

## Waveguiding



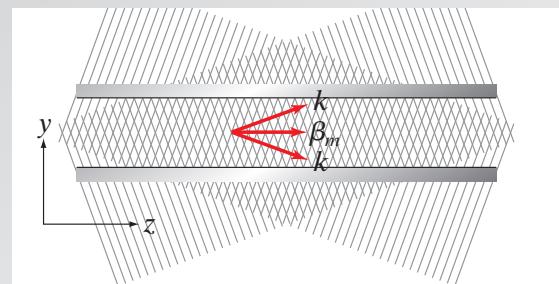
number of modes:

$$M \doteq \frac{\sin(\pi/2 - \theta_c)}{\lambda/2d}$$

or:

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2}$$

## Waveguiding



propagation constant of guided wave:

$$\beta_m^2 = k^2 - k_y^2 = k^2 - \frac{m^2 \pi^2}{d^2}$$

group velocity:

$$v_m = c \cos \theta_m$$

## Waveguiding

single mode condition for 600-nm light:

planar mirror

$$M \doteq \frac{2d}{\lambda} \quad 300 < d < 600 \text{ nm}$$

dielectric

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2} \quad d < 268 \text{ nm}$$

## Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_o \epsilon \vec{A} = 0$$

Substituting

$$\vec{A} = \hat{y} u(x, y) e^{-i \beta z}$$

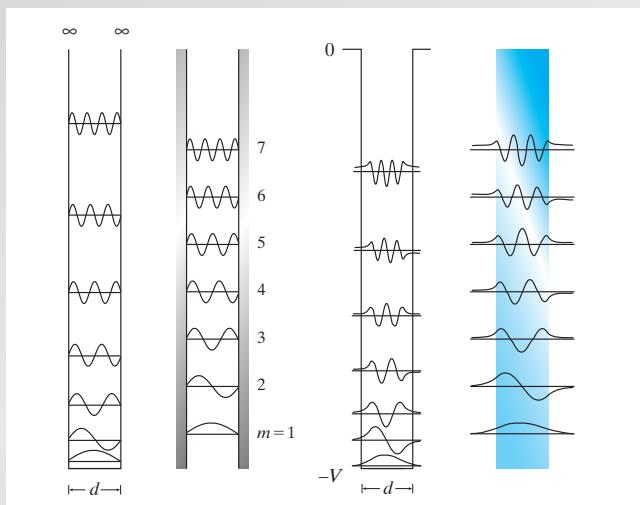
yields:

$$\nabla_T^2 u + [-\beta^2 + \omega^2 \mu \epsilon(r)] u = 0$$

Compare to time-independent Schrödinger equation:

$$\nabla^2 \psi + \frac{2m}{\hbar^2} [E - V(r)] \psi = 0$$

## Waveguiding



## Waveguiding

single mode condition for 600-nm light:

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2}$$

without cladding:  $d < 268 \text{ nm}$

Add cladding with 0.4% index difference:

$$d < 5 \mu\text{m}$$

## Waveguiding

commercial single-mode fiber (Corning Titan®)



core

cladding

index

$n_1 = 1.468$

$n_2 = 1.462$

diameter:

$8.3 \mu\text{m}$

$125.0 \pm 1.0 \mu\text{m}$

operating wavelength:  $\lambda = 1310 \text{ nm}/1550 \text{ nm}$

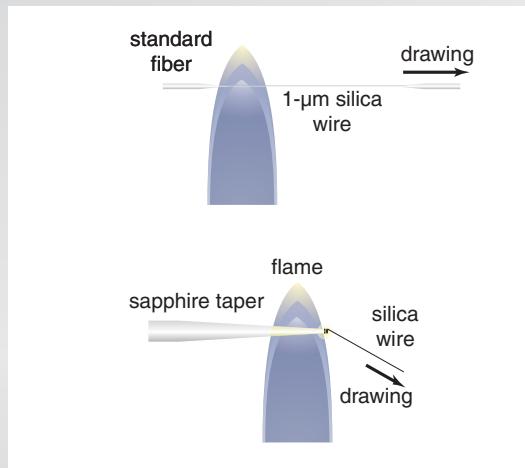
## Waveguiding

drawbacks of clad fibers:

- weak confinement
- no tight bending
- coupling requires splicing

## Nanowire fabrication

two-step drawing process



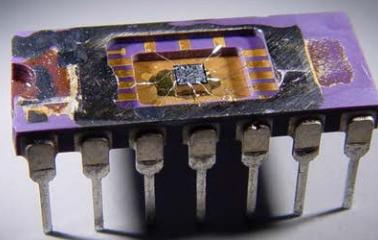
## Nanowire fabrication

1 μm



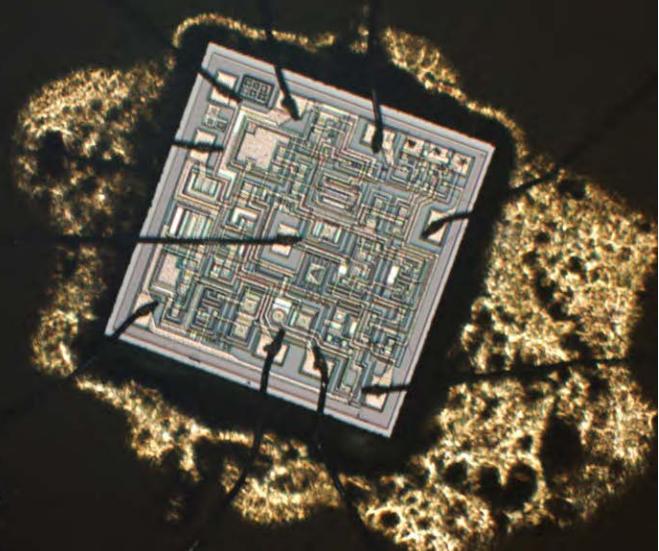
*Nature*, 426, 816 (2003)

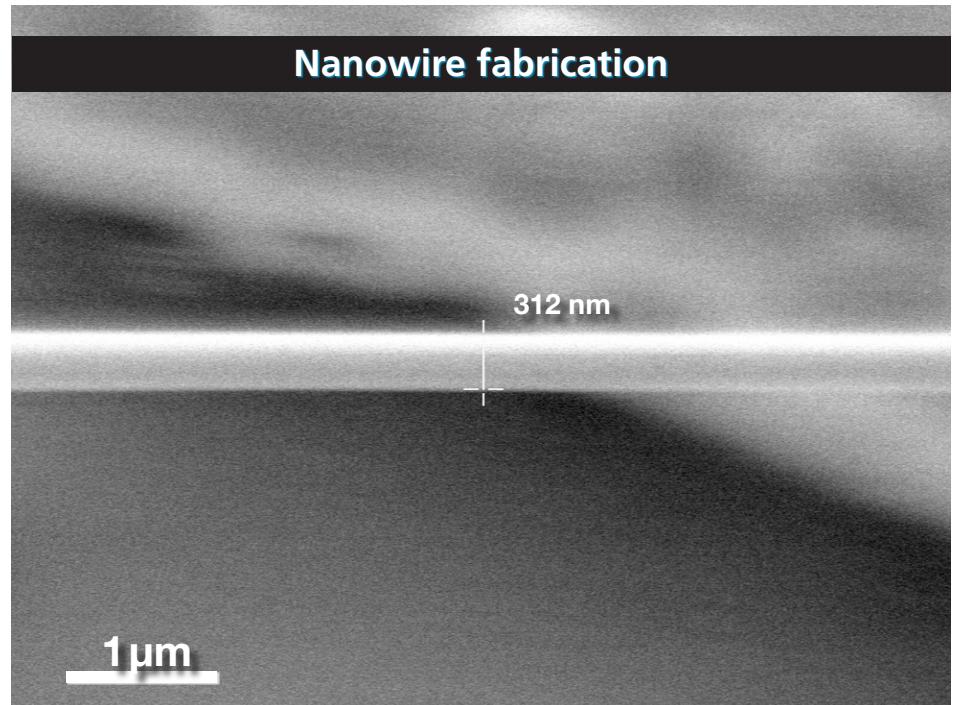
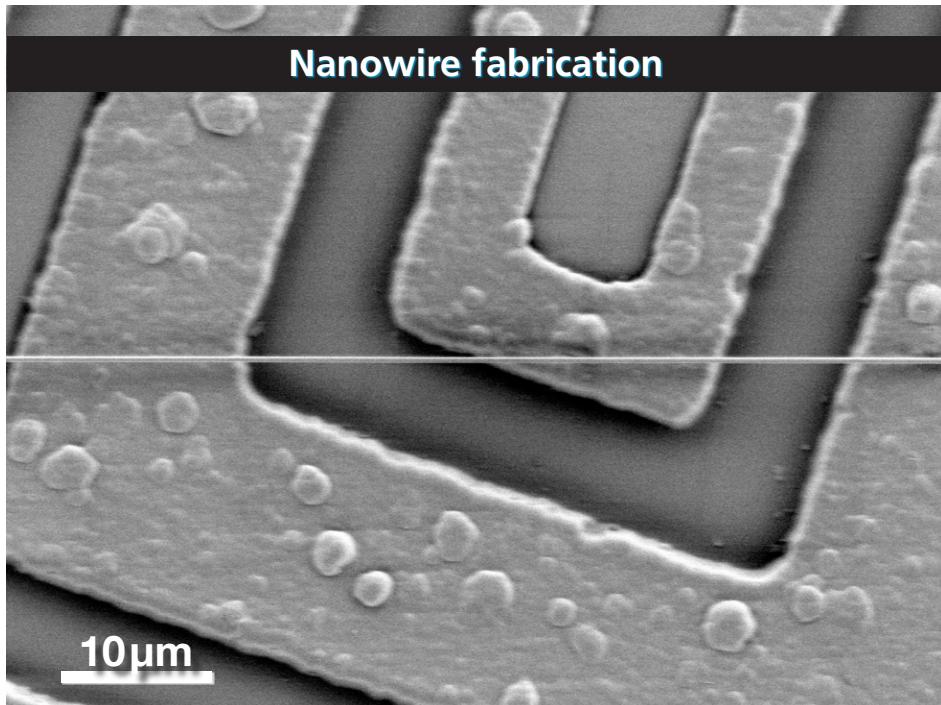
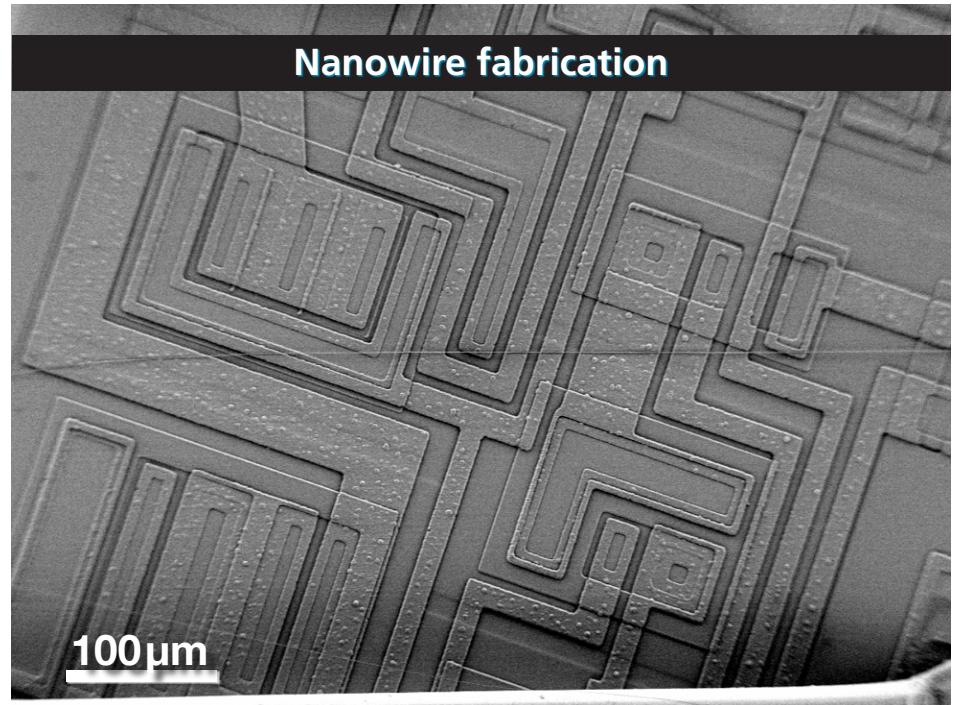
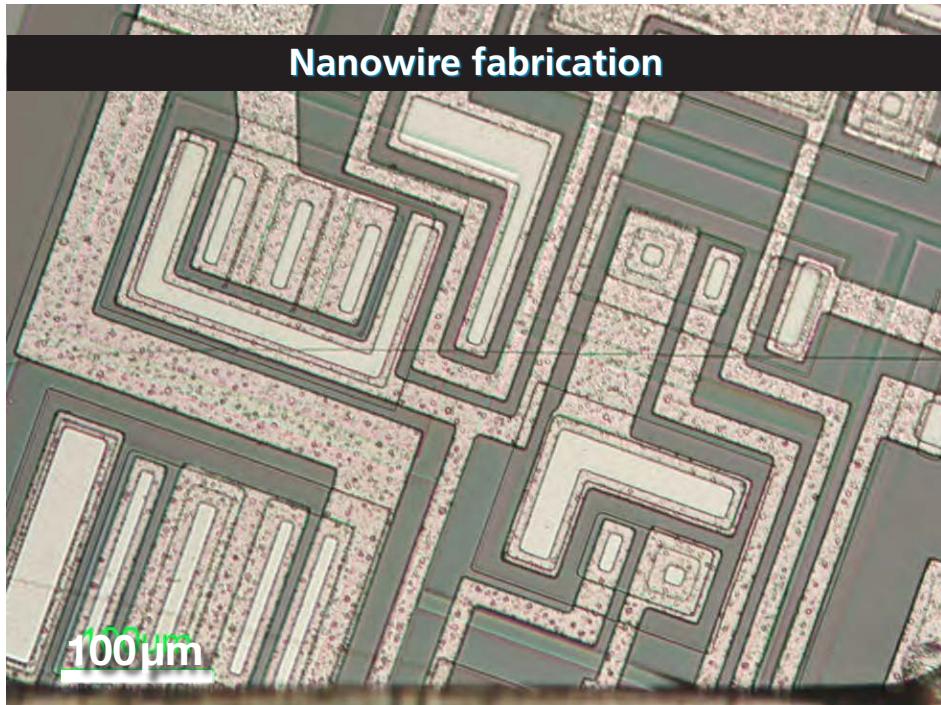
## Nanowire fabrication



## Nanowire fabrication

1000 μm





## Waveguiding

### Specifications

diameter $D$ :	down to 20 nm
length $L$ :	up to 90 mm
aspect ratio $D/L$ :	up to $10^6$
diameter uniformity $\Delta D/L$ :	$2 \times 10^{-6}$

*Nature*, 426, 816 (2003)

## Nanowire fabrication

$d = 260$  nm  
 $L = 4$  mm

50  $\mu\text{m}$

## Nanowire fabrication

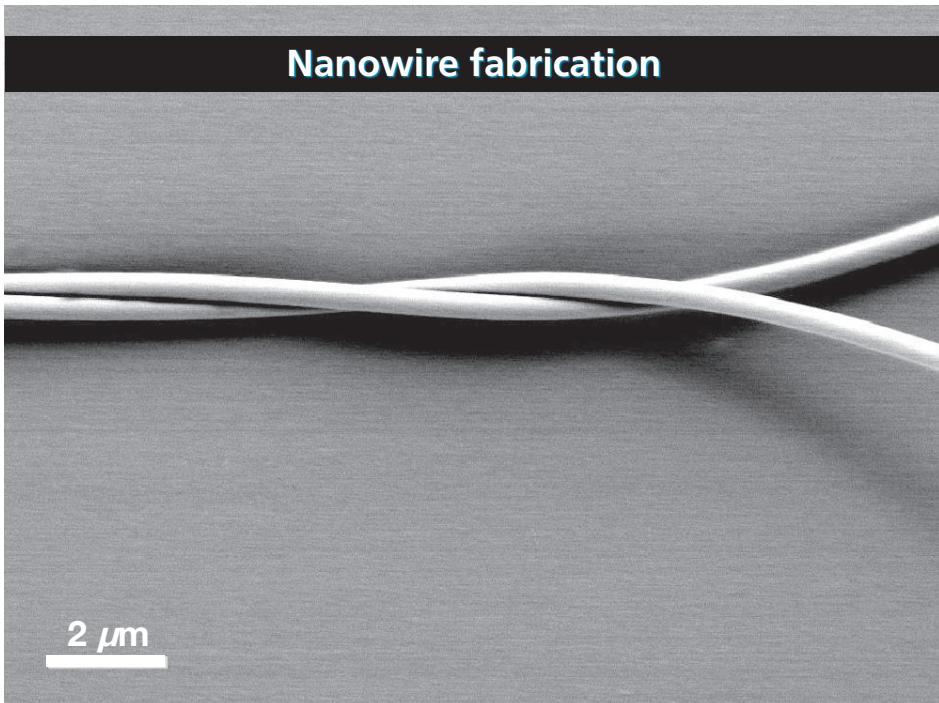
240-nm wire

200 nm

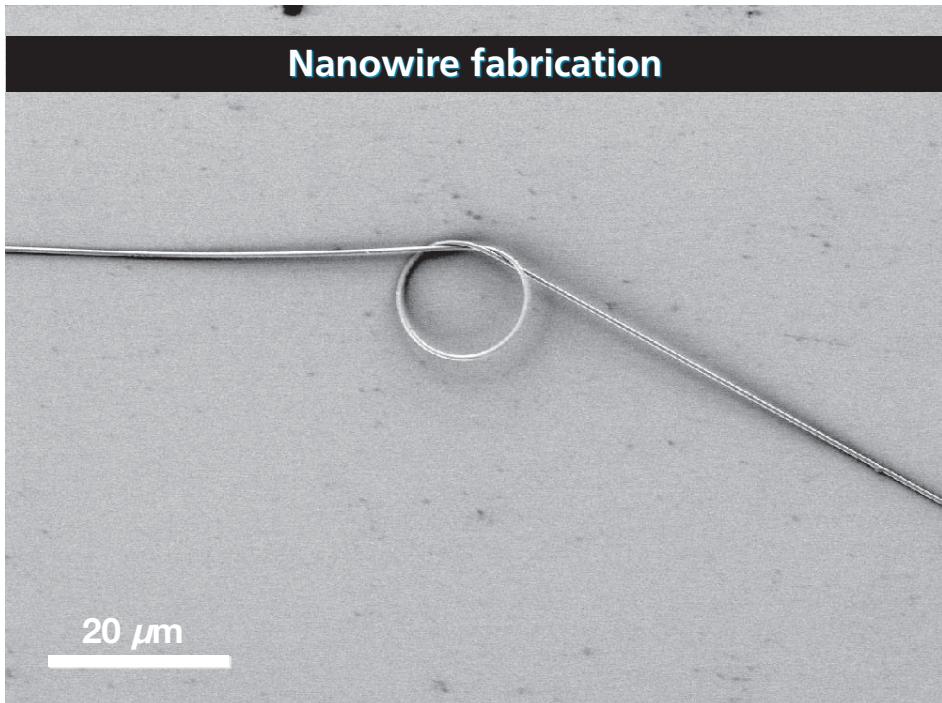
## Nanowire fabrication

20 nm

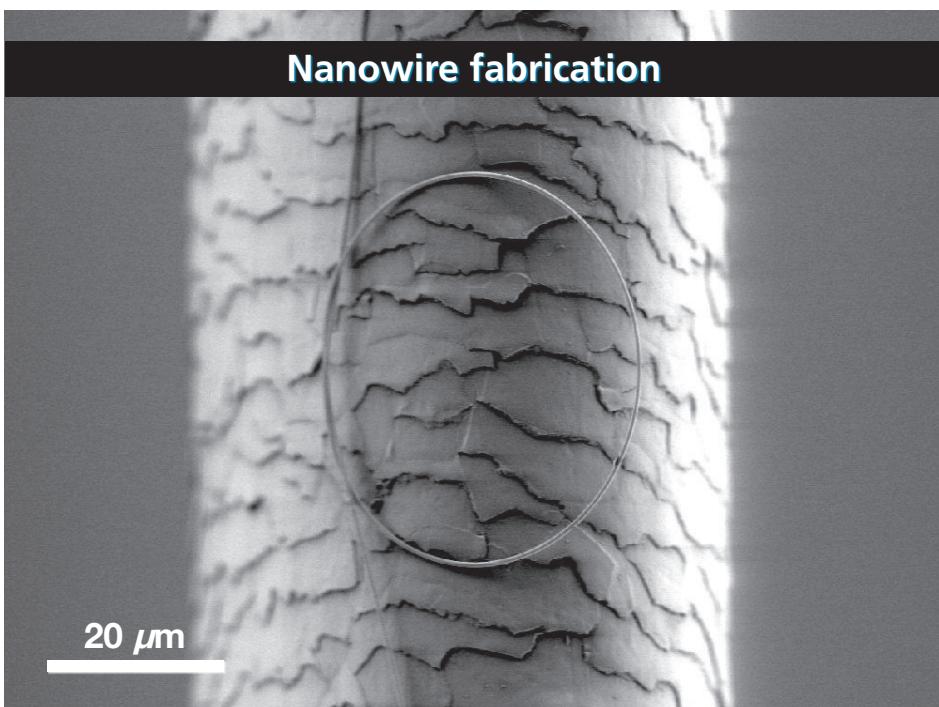
## Nanowire fabrication



## Nanowire fabrication

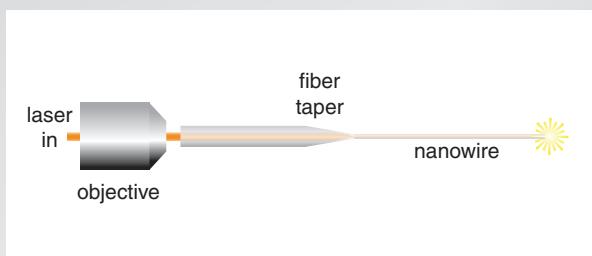


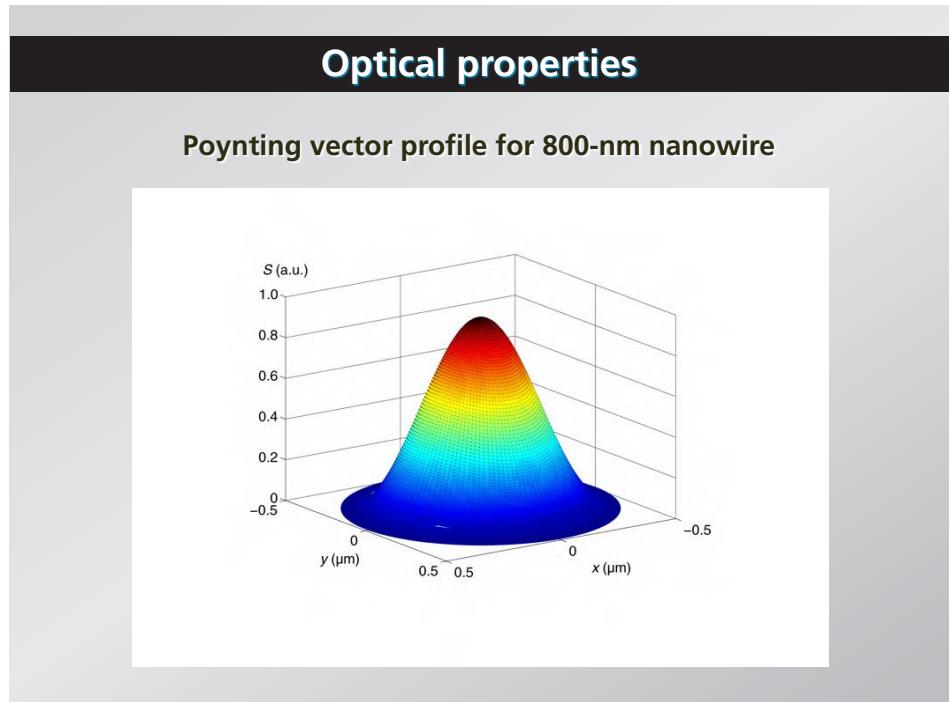
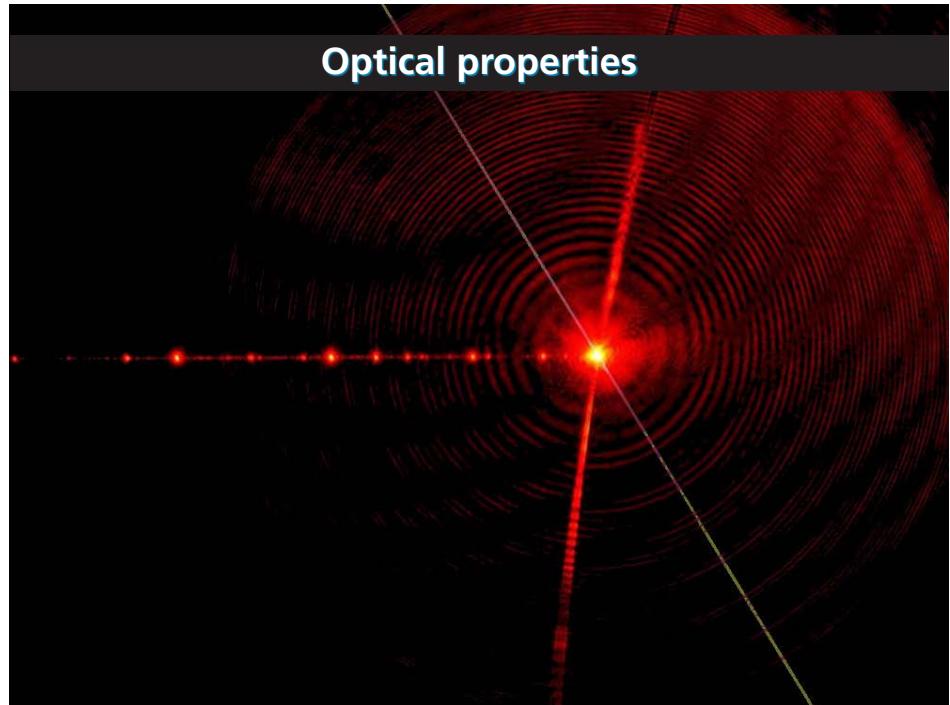
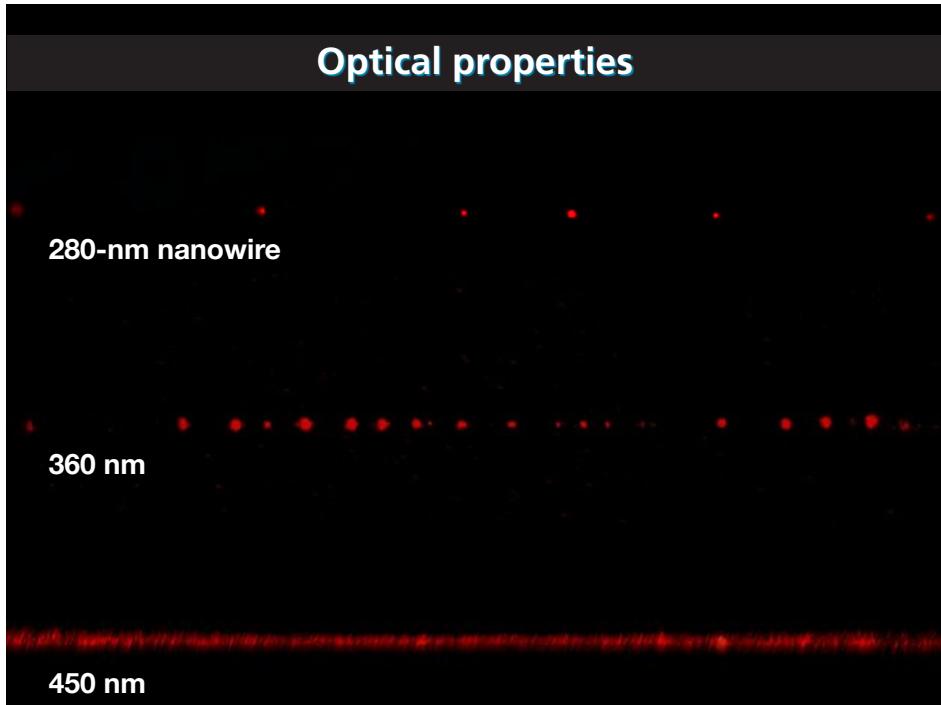
## Nanowire fabrication



## Optical properties

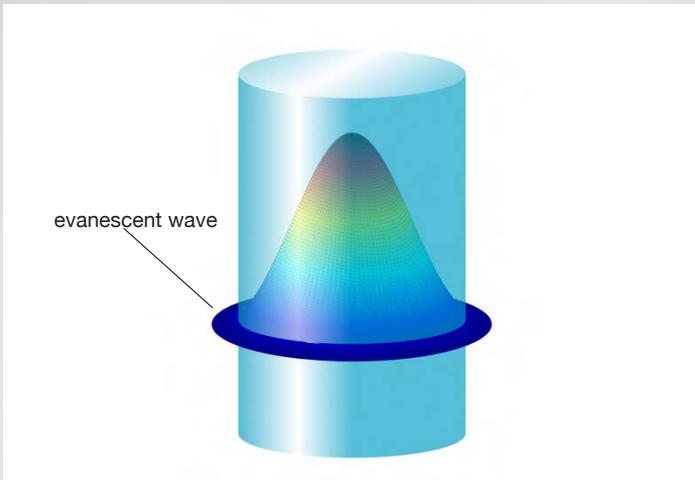
coupling light into nanowires





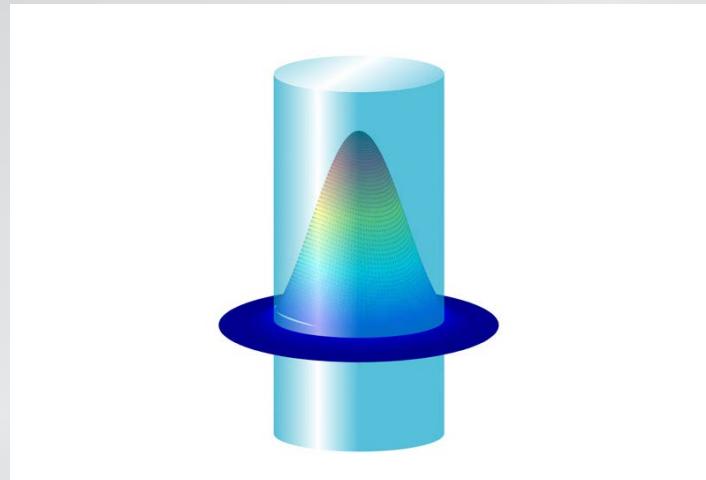
## Optical properties

Poynting vector profile for 800-nm nanowire



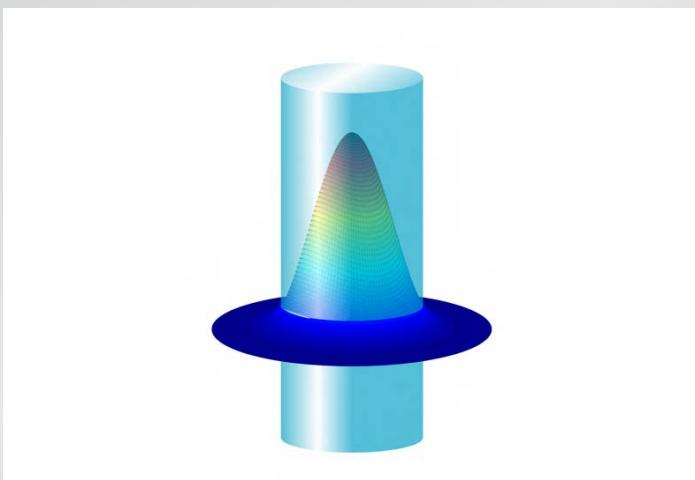
## Optical properties

Poynting vector profile for 600-nm nanowire



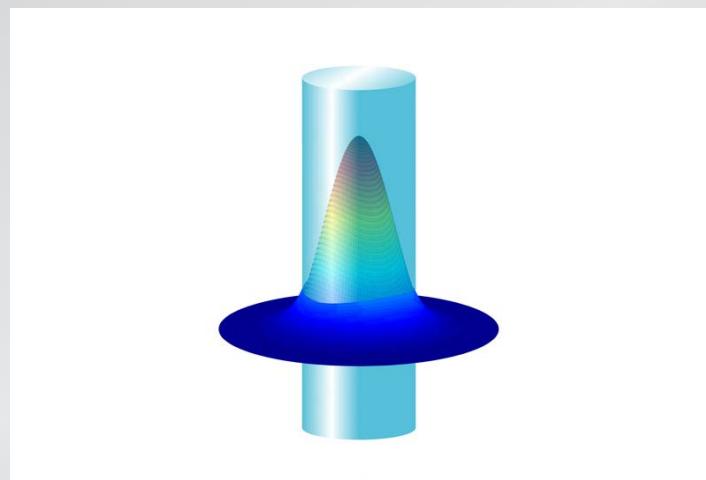
## Optical properties

Poynting vector profile for 500-nm nanowire



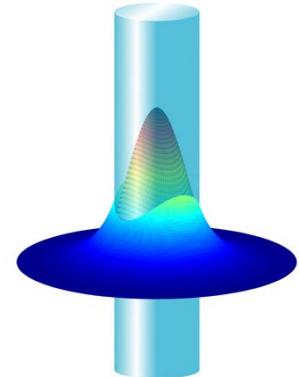
## Optical properties

Poynting vector profile for 400-nm nanowire



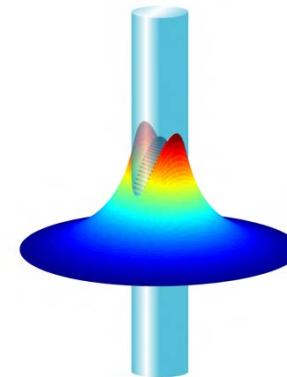
## Optical properties

Poynting vector profile for 300-nm nanowire



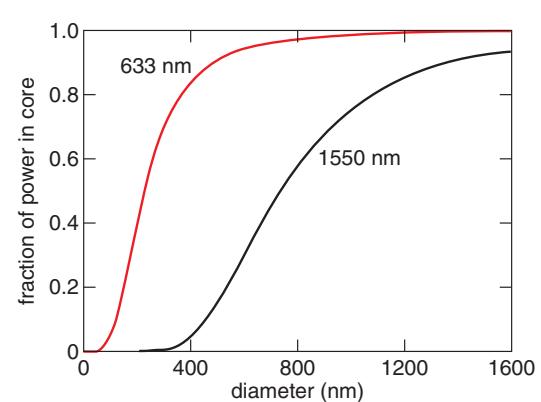
## Optical properties

Poynting vector profile for 200-nm nanowire



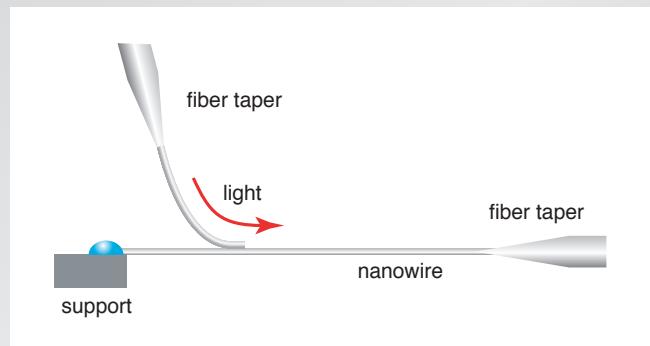
## Waveguiding

fraction of power carried in core

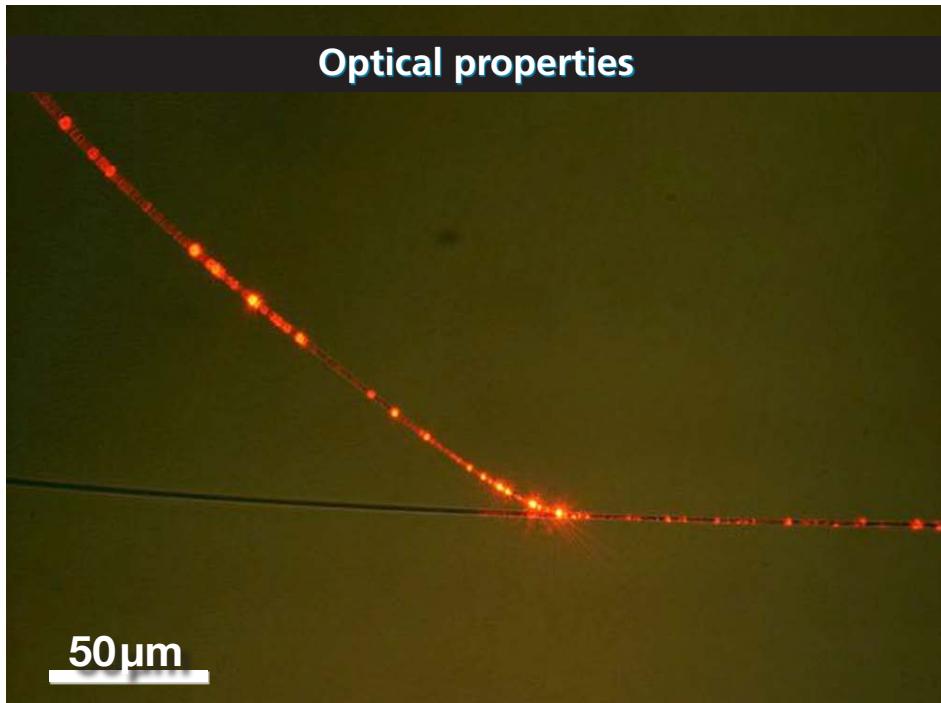


## Optical properties

coupling light between nanowires

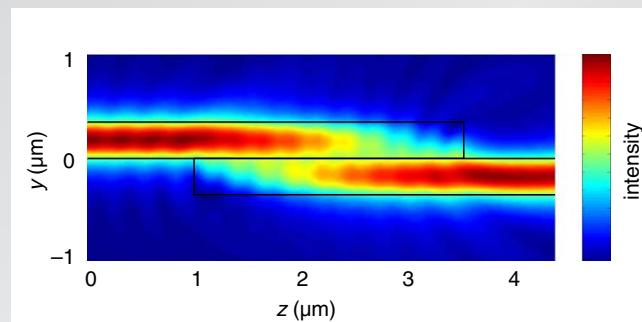


## Optical properties

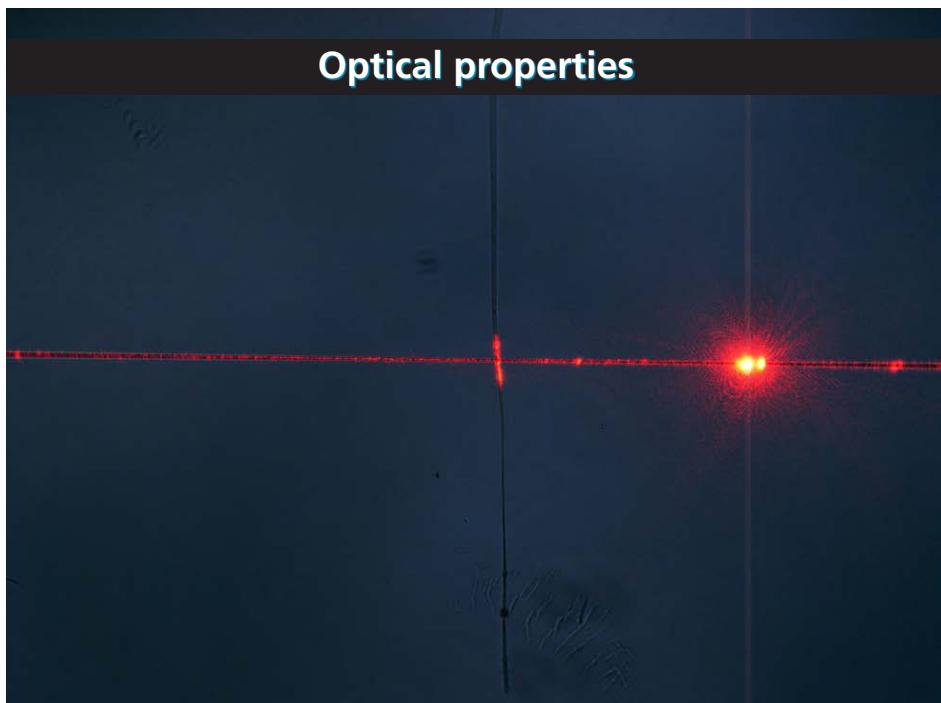


## Optical properties

### intensity distribution

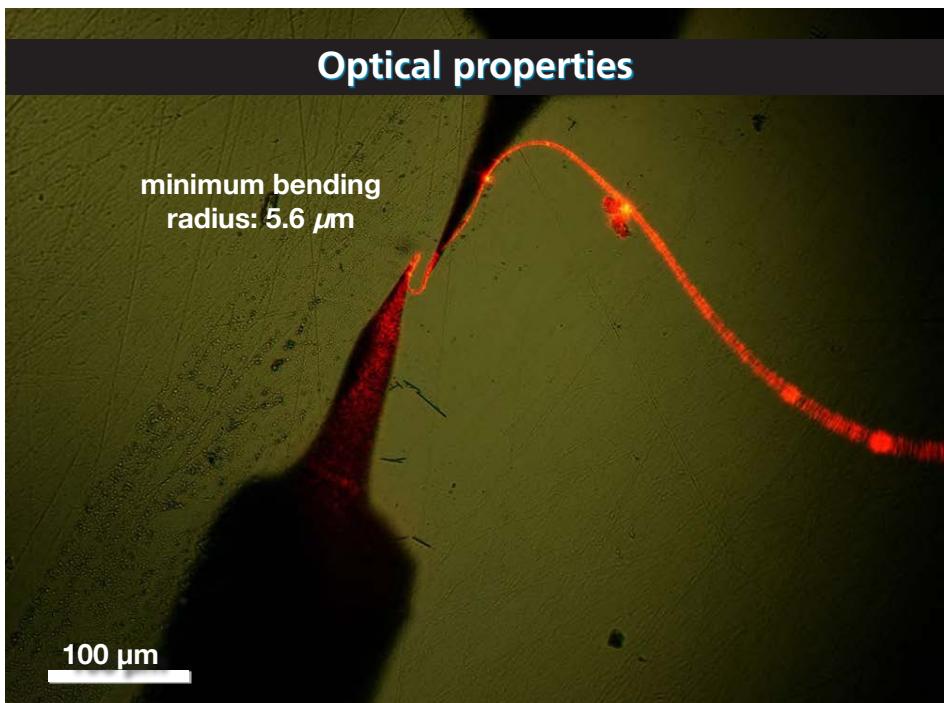


## Optical properties



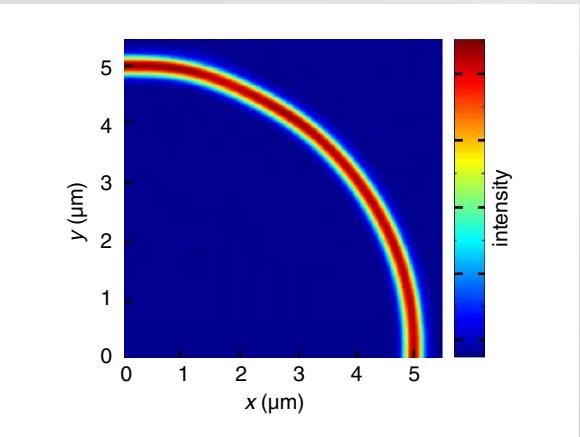
## Optical properties

minimum bending  
radius:  $5.6\text{ }\mu\text{m}$



## Optical properties

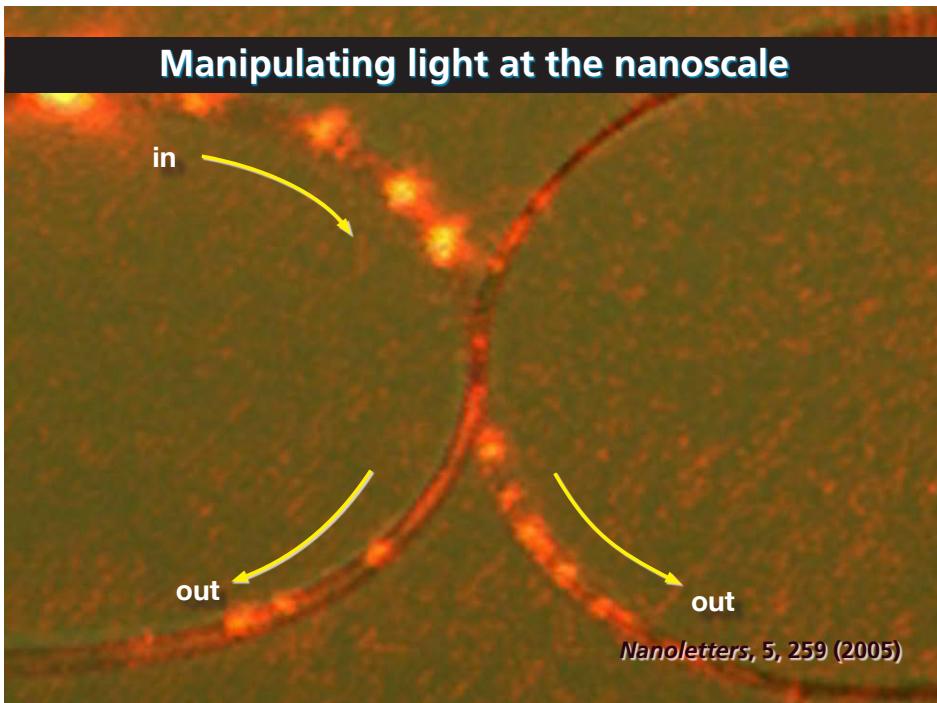
virtually no loss through 5  $\mu\text{m}$  corner!



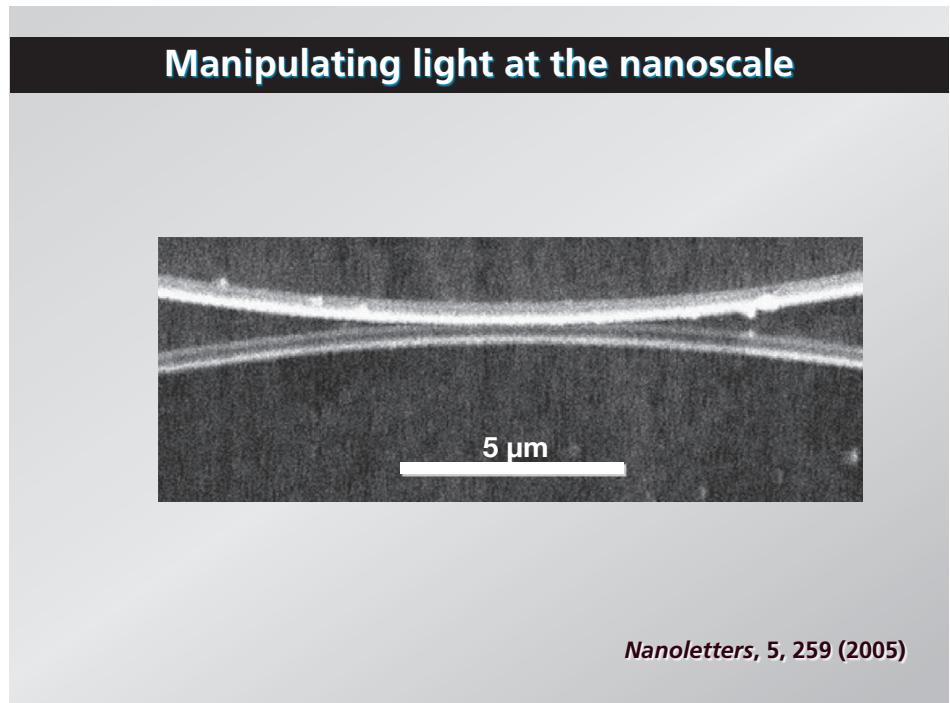
## Manipulating light at the nanoscale



## Manipulating light at the nanoscale



## Manipulating light at the nanoscale



## Manipulating light at the nanoscale

Points to keep in mind:

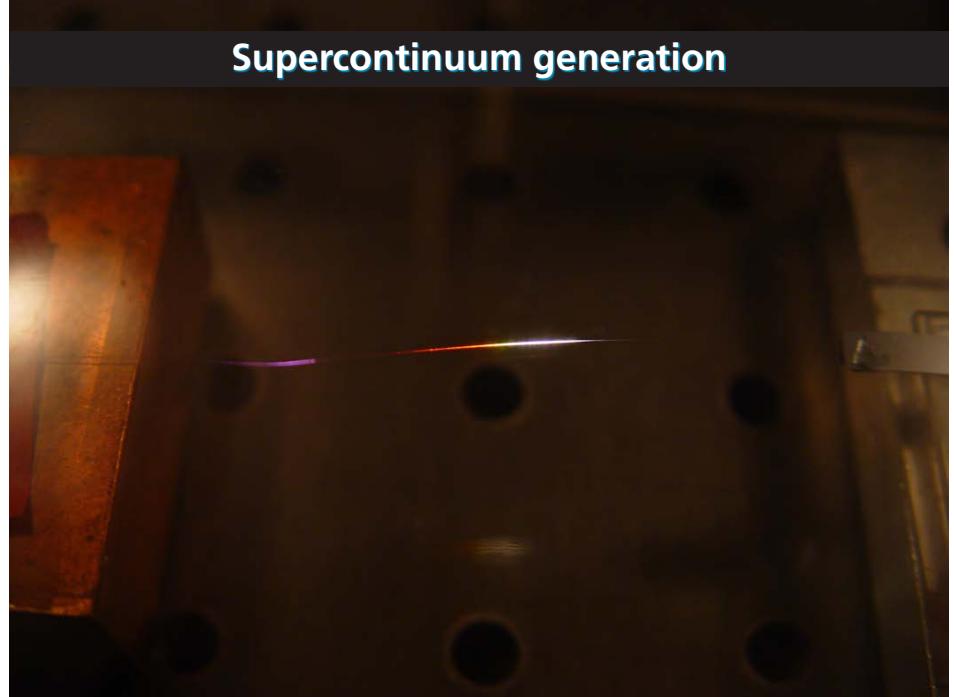
- low-loss guiding
- convenient evanescent coupling
- attached to ordinary fiber

## Outline

- propagation of pulses
- nonlinear optics
- nanoscale optics
- nonlinear optics at the nanoscale

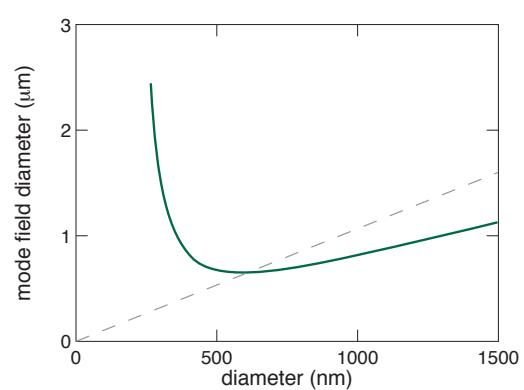
## Supercontinuum generation

strong confinement → high intensity



## Supercontinuum generation

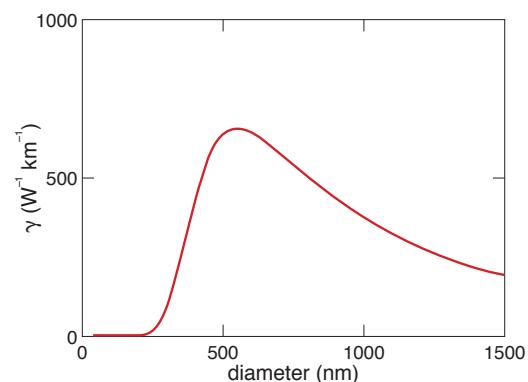
mode field diameter ( $\lambda = 800 \text{ nm}$ )



M.A. Foster, et al., *Optics Express*, 12, 2880 (2004)

## Supercontinuum generation

nonlinear parameter



M.A. Foster, et al., *Optics Express*, 12, 2880 (2004)

## Supercontinuum generation

dispersion important!

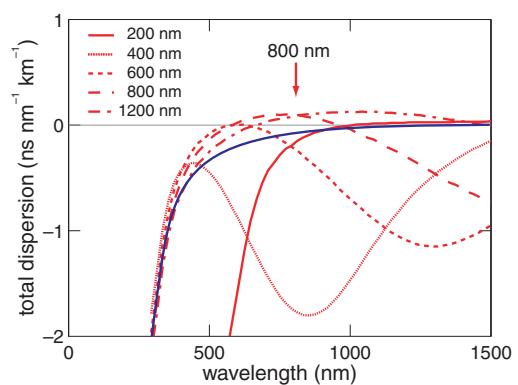
## Supercontinuum generation

dispersion:

- modal dispersion
- material dispersion
- waveguide dispersion
- nonlinear dispersion

## Supercontinuum generation

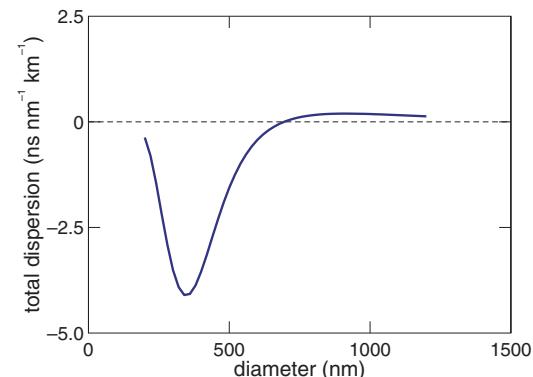
### waveguide dispersion



*Optics Express*, 12, 1025 (2004)

## Supercontinuum generation

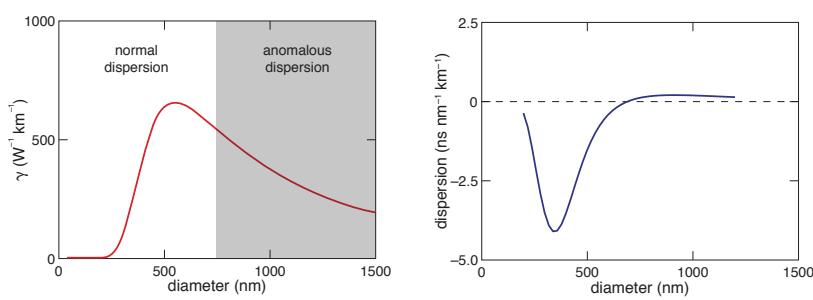
### waveguide dispersion



*Optics Express*, 12, 1025 (2004)

## Supercontinuum generation

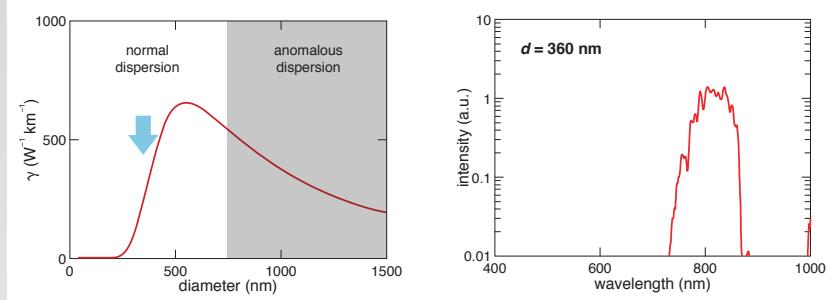
### waveguide dispersion



*Optics Express*, 12, 1025 (2004)

## Supercontinuum generation

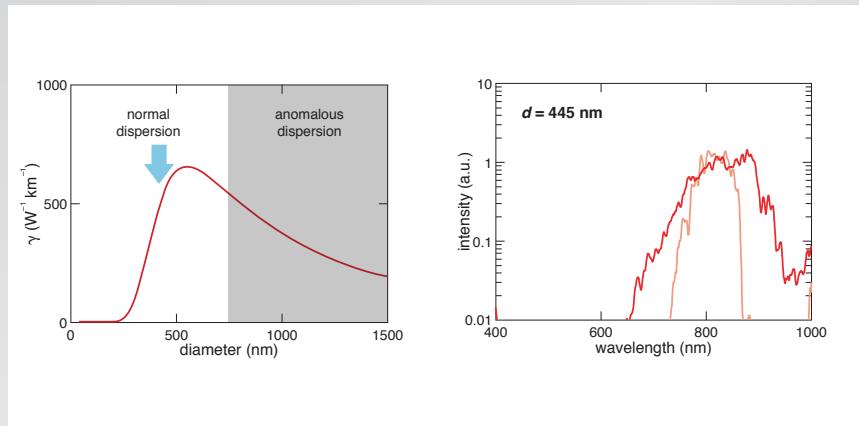
### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

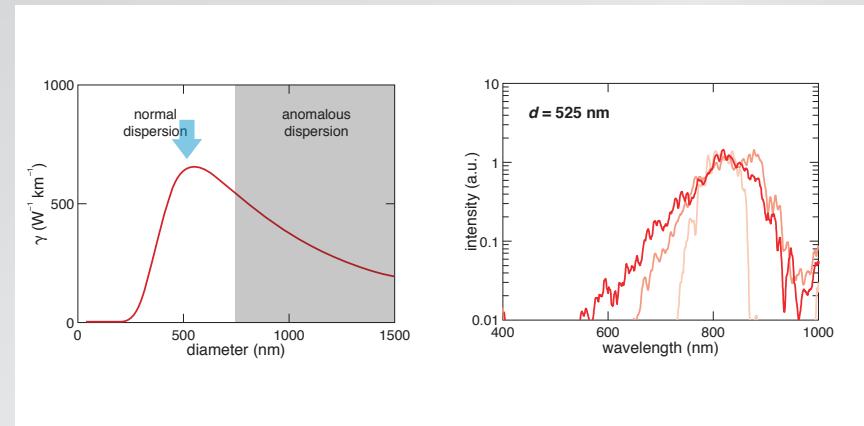
### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

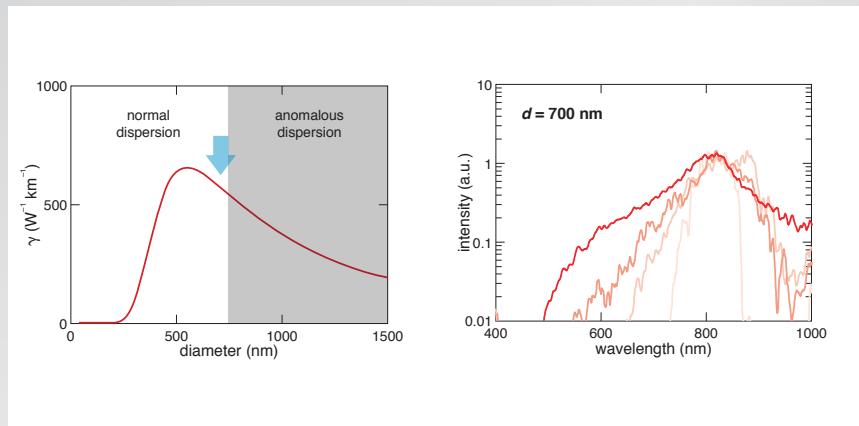
### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

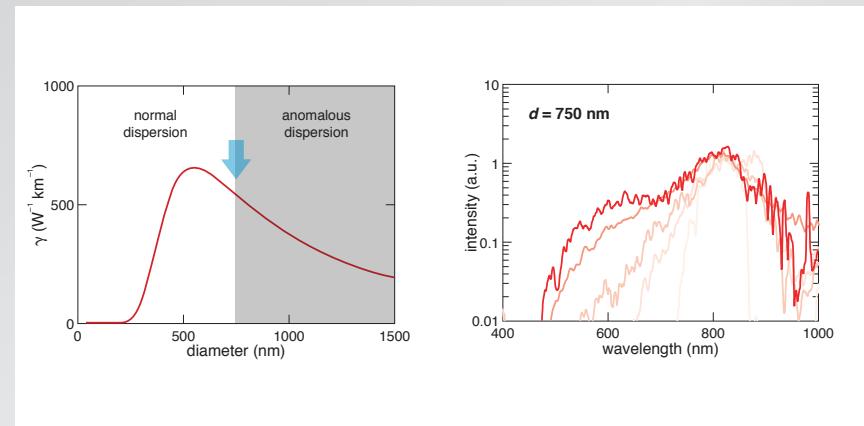
### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

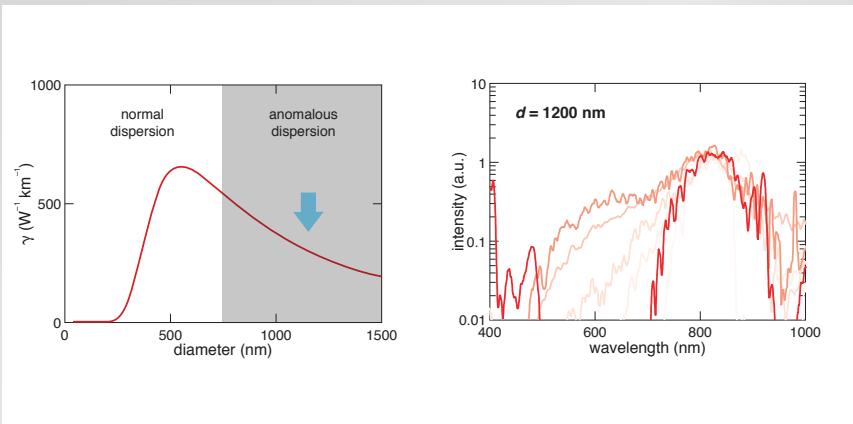
### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

### nanowire continuum generation



*Optics Express*, 14, 9408 (2006)

## Supercontinuum generation

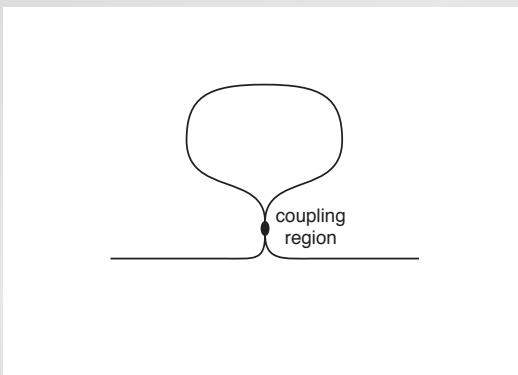
energy in nanowire  $\approx 1 \text{ nJ!}$

## Supercontinuum generation

- nanojoule nonlinear optics
- optimum diameter for silica 500–600 nm
- low dispersion

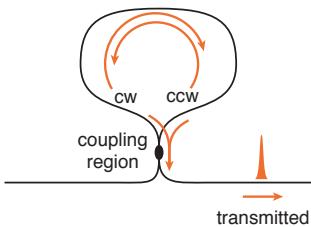
## Optical logic gates

### nanowire Sagnac interferometer



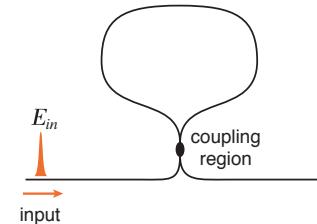
## Optical logic gates

output = transmitted cw + ccw power



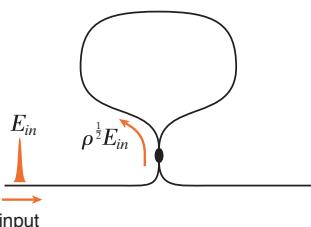
## Optical logic gates

input electric field amplitude  $E_{in}$



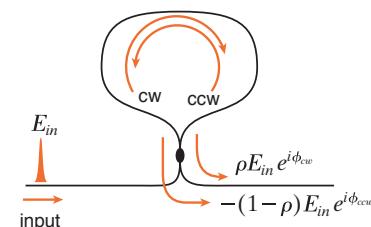
## Optical logic gates

coupling parameter:  $\rho$



## Optical logic gates

output is sum of transmitted cw and ccw



## Manipulating light at the nanoscale

accumulated phase:

$$\phi = k_o n L$$

nonlinear index:

$$n = n_o + n_2 I = n_o + n_2 \frac{P_i}{A_{eff}}$$

nonlinear parameter:

$$\gamma = n_2 \frac{k_o}{A_{eff}}$$

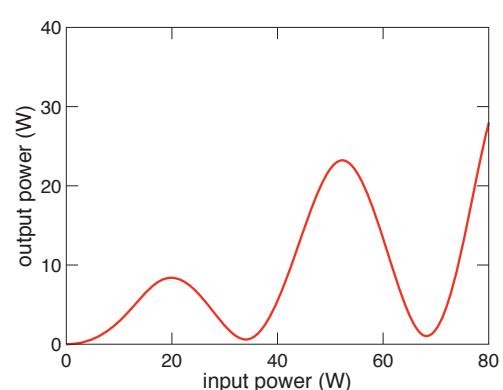
## Manipulating light at the nanoscale

power-dependent output:

$$\frac{E_{out}^2}{E_{in}^2} = 1 - 2\rho(1 - \rho)\{1 + \cos[(1 - 2\rho)\gamma P_o L]\}$$

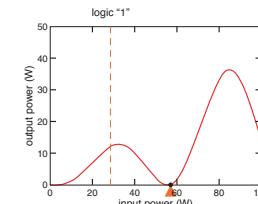
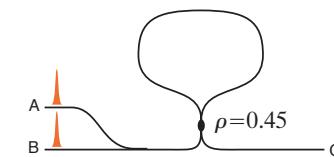
## Optical logic gates

when  $\rho \neq 0.5$ :



## Optical logic gates

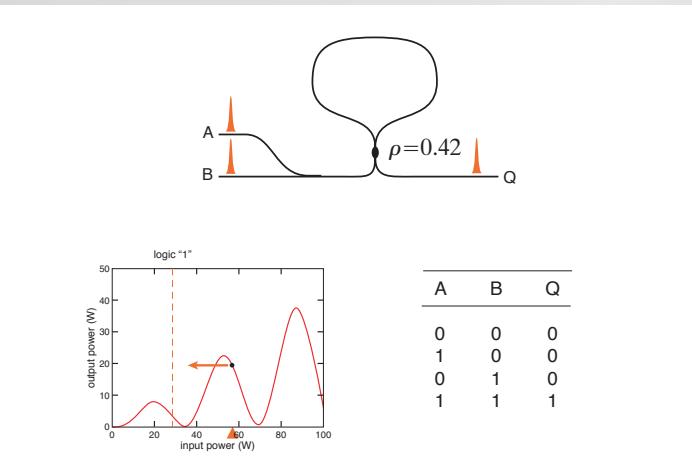
nonlinear nanogate



A	B	Q
0	0	0
1	0	1
0	1	1
1	1	0

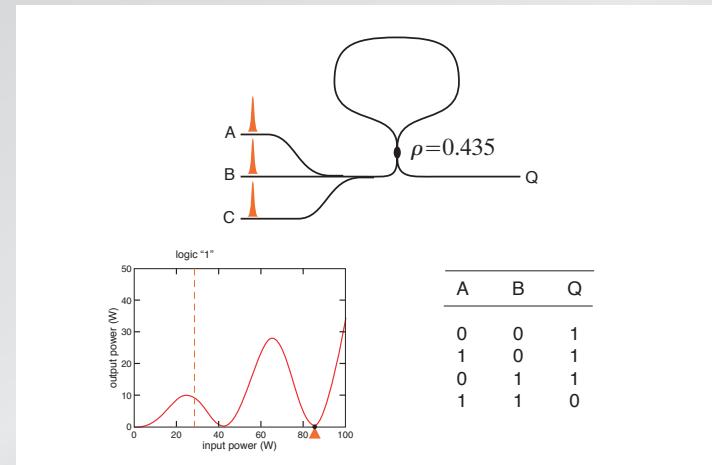
## Optical logic gates

### nonlinear nanogate

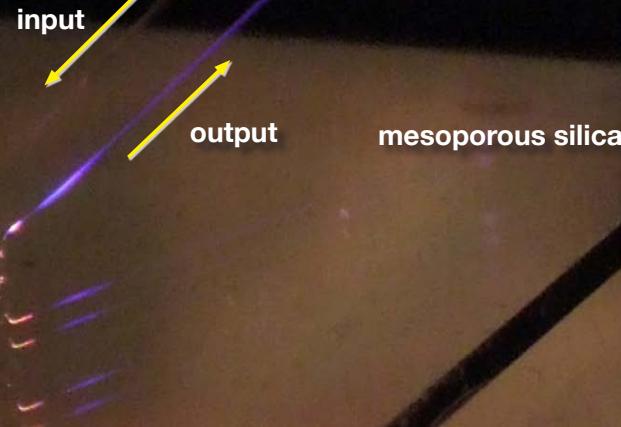


## Optical logic gates

### universal NAND gate

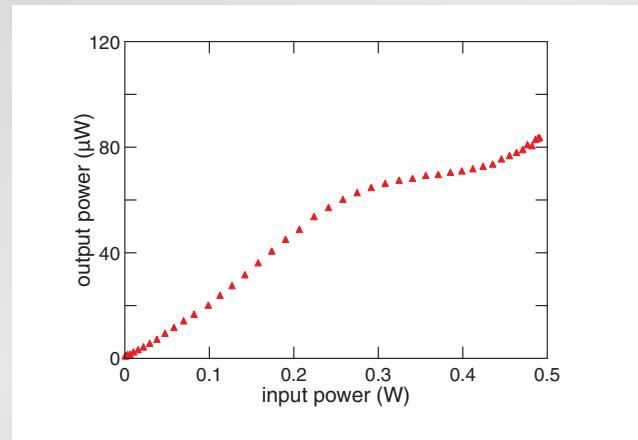


## Optical logic gates



## Optical logic gates

### very preliminary data

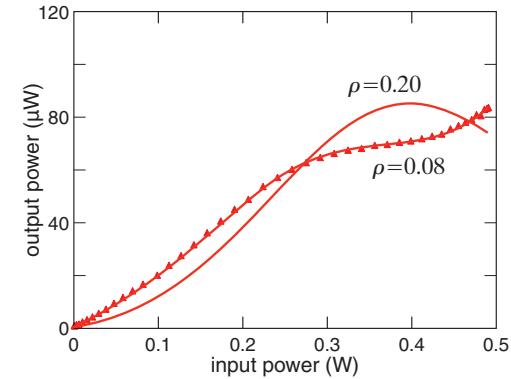


## Optical logic gates

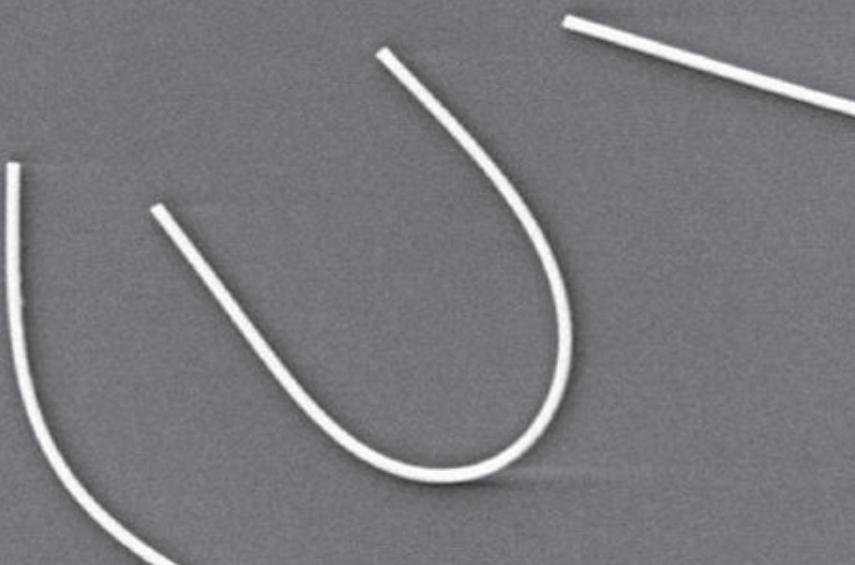
light-by-light modulation!

## Optical logic gates

very preliminary data



## Optical logic gates

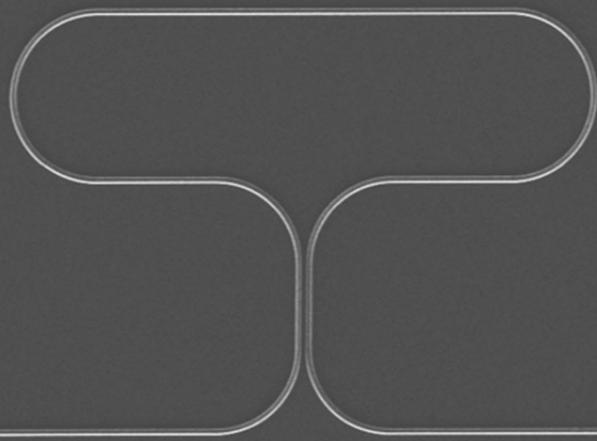


## Optical logic gates

need a different approach!

- lithographic fabrication
- greater index
- greater nonlinearity

## Optical logic gates



10  $\mu\text{m}$

## Optical logic gates

reactive sputtering of titanium with oxygen

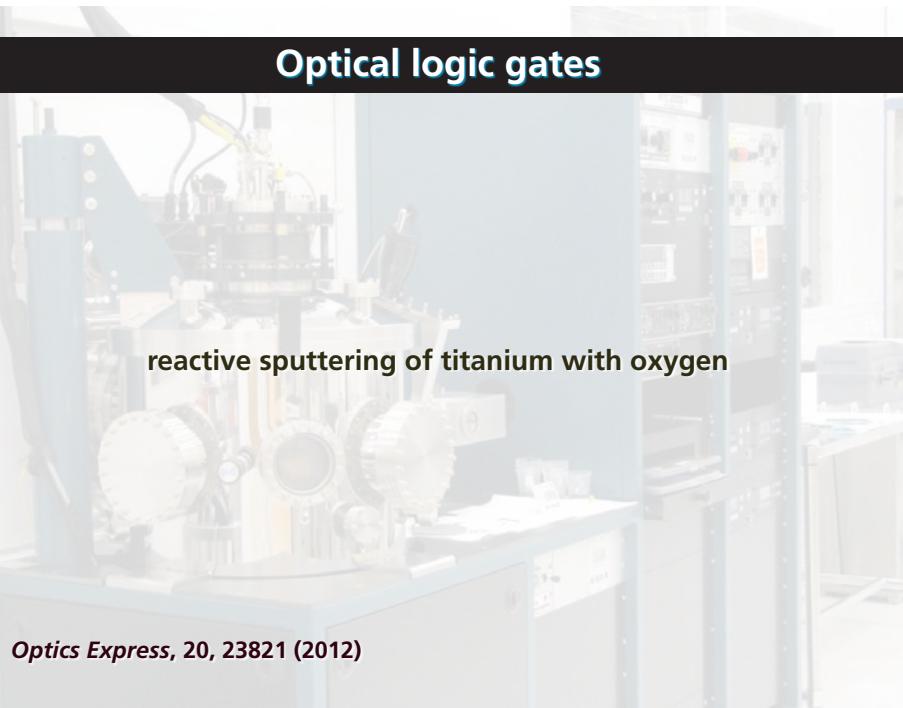
*Optics Express*, 20, 23821 (2012)

## Optical logic gates

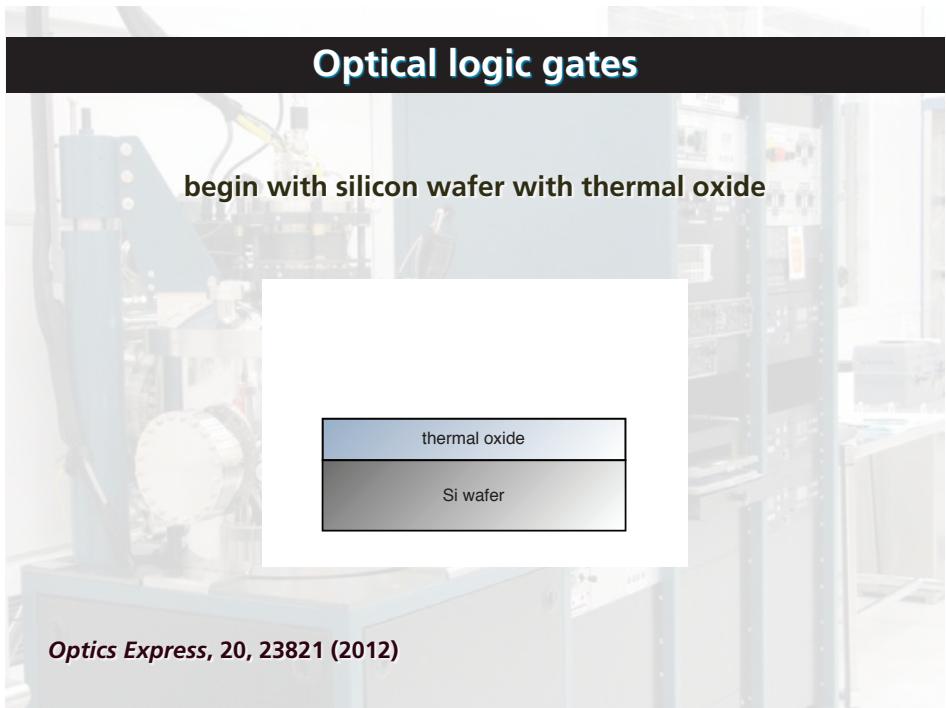
TiO<sub>2</sub> properties

- large nonlinearity
- high index of refraction
- wide bandgap
- low two-photon absorption
- effective nonlinearity

- 30x silica
- 2.4
- 3.1 eV
- > 800 nm
- 50,000  $\text{W}^{-1} \text{ km}^{-1}$



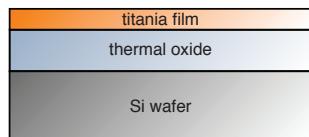
*Optics Express*, 20, 23821 (2012)



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

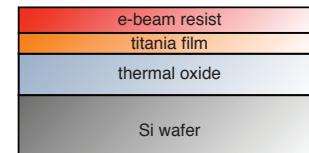
deposit titania using reactive sputtering



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

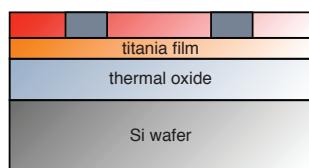
spin on e-beam resist



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

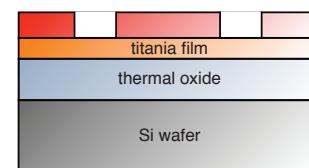
write pattern using e-beam



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

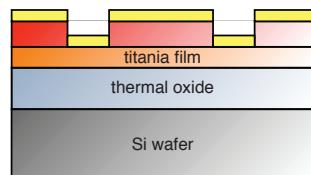
develop to remove exposed regions



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

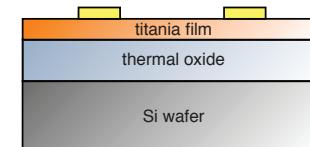
deposit thin metal film



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

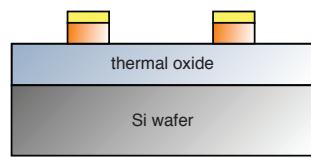
dissolve resist, lift off metal film



*Optics Express*, 20, 23821 (2012)

## Optical logic gates

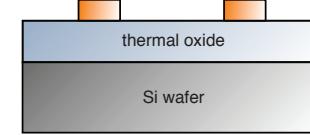
reactive ion etch through titania film



*Optics Express*, 20, 23821 (2012)

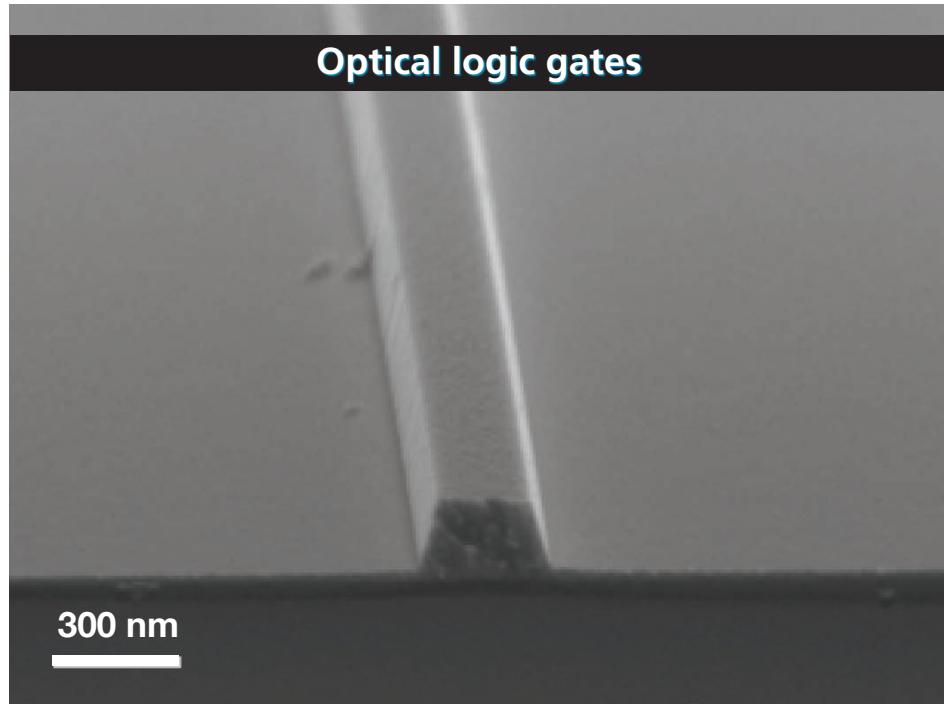
## Optical logic gates

remove remaining metal

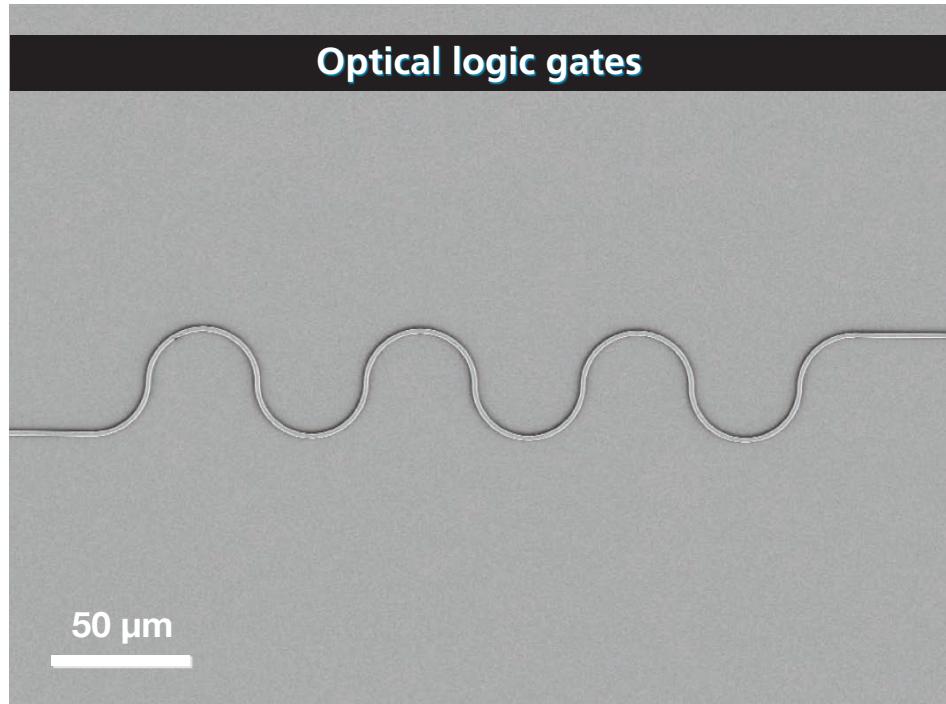


*Optics Express*, 20, 23821 (2012)

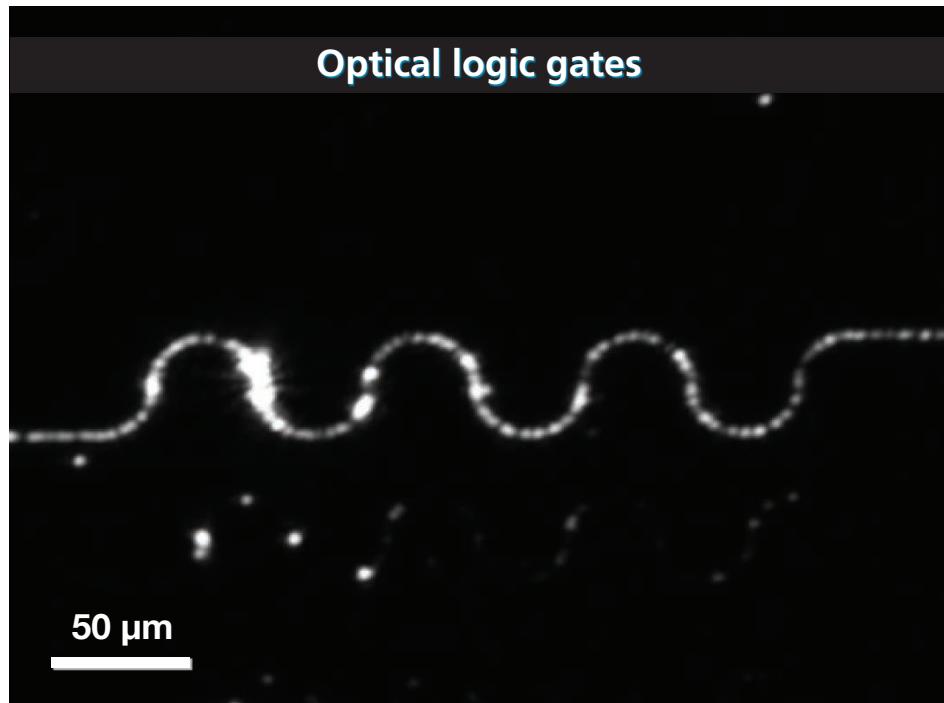
### Optical logic gates



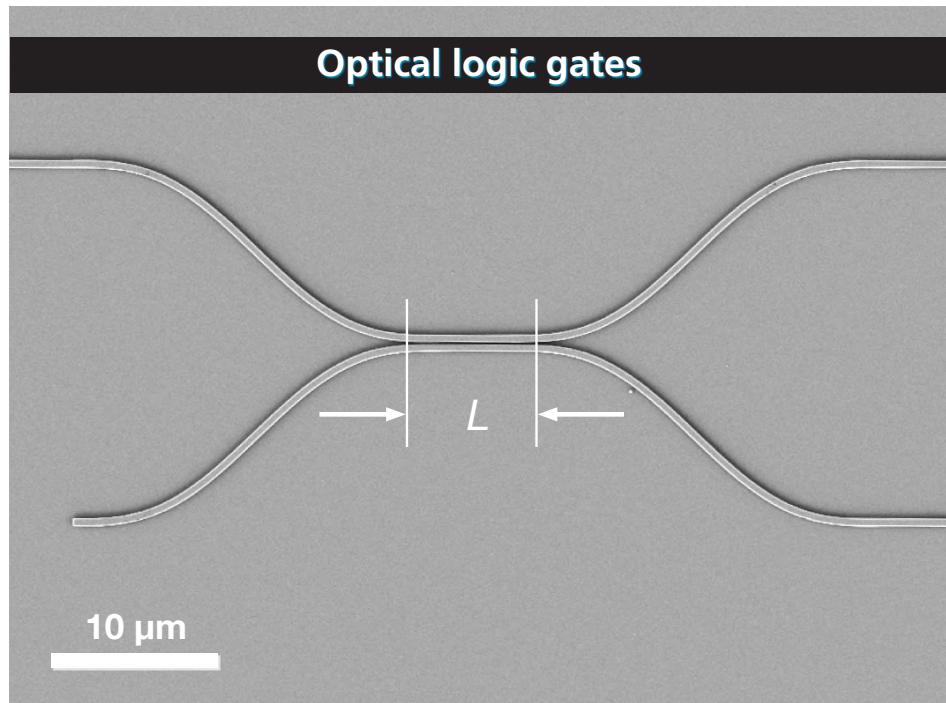
### Optical logic gates



### Optical logic gates



### Optical logic gates



## Optical logic gates

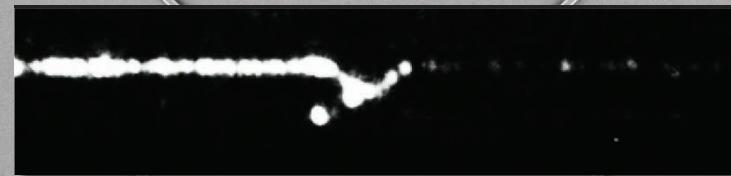
$L = 0 \mu\text{m}$



10  $\mu\text{m}$

## Optical logic gates

$L = 4 \mu\text{m}$



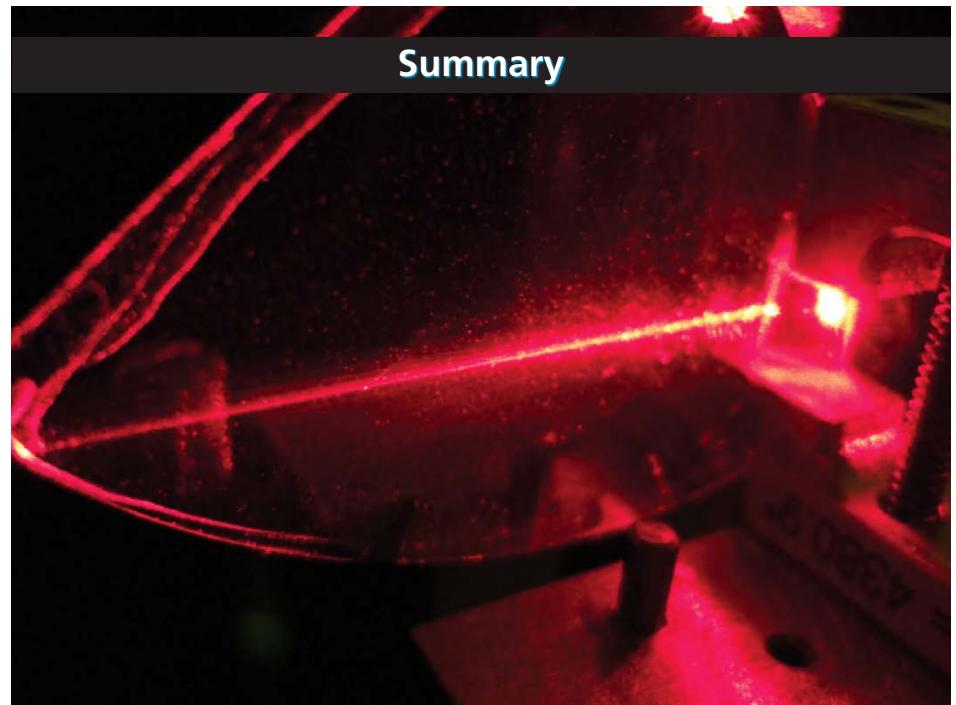
10  $\mu\text{m}$

## Optical logic gates



10  $\mu\text{m}$

## Summary



## Summary

- several nanodevices demonstrated
- large  $\gamma$  permits miniature Sagnac loops
- switching energy  $\approx 100$  pJ

## Summary

